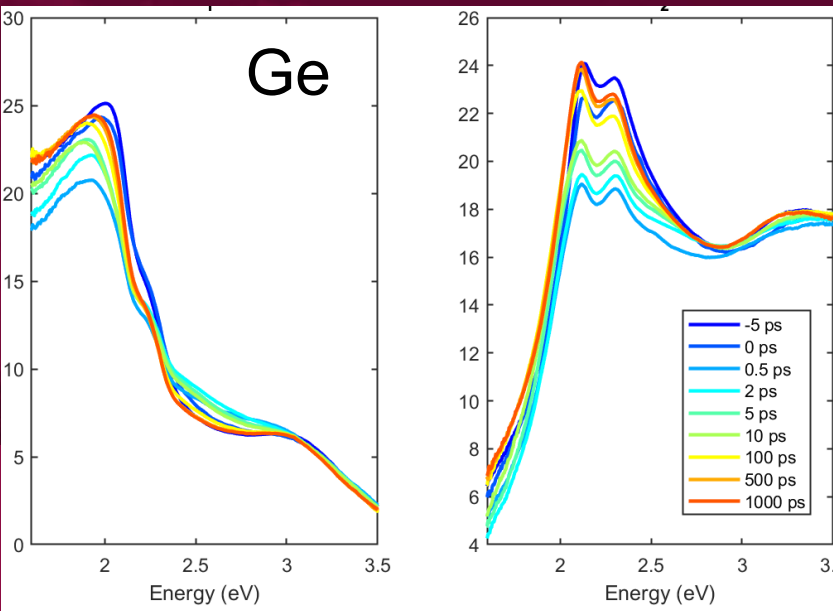




# Accurate measurements and models of temperature-dependent optical constants for infrared detector materials



Stefan Zollner

With Carlos A. Armenta, Carola Emminger,  
Sonam Yadav, Melissa Rivero Arias, Jaden R.  
Love (NMSU), Jose Mendendez (Arizona State)

Department of Physics, New Mexico State University,  
Las Cruces, NM, USA

Email: [zollner@nmsu.edu](mailto:zollner@nmsu.edu). WWW: <http://femto.nmsu.edu>.

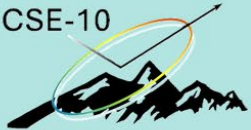
# Precision measurements of optical constants

- 1) Bulk materials: Semiconductors, metals, insulators  
SiC, SrTiO<sub>3</sub>, AlSb, Ge, GaAs, GaP, GaSb, InSb, SiC (4H and 6H), Ni, Pt, Au, MgAl<sub>2</sub>O<sub>4</sub>, NiO (excitons), LiF, LSAT, ZnGa<sub>2</sub>O<sub>4</sub>, LaAlO<sub>3</sub>
- 2) Epitaxial layers (CVD, MBE, ALD):  
NbO<sub>2</sub>, Co<sub>3</sub>O<sub>4</sub>, SrTiO<sub>3</sub> (doped, quantum wells), BaSnO<sub>3</sub>, ZnO, SnO<sub>2</sub>, HfO<sub>2</sub>, Gd<sub>x</sub>Ga<sub>2-x</sub>O<sub>3</sub>, silicides, SiGe:C, GeSn, GaAs<sub>1-x</sub>P<sub>x</sub>, alpha-tin on InSb and CdTe, native oxides on semiconductors (GeO<sub>2</sub>)
- 3) Comparison with *ab initio* density functional theory and with **k.p theory** (Jose Menendez)
- 4) Ellipsometry measurements over a broad **spectral range** (30 meV to 9.5 eV) and broad **temperature** range (4 K to 800 K). Also **femtosecond** time resolution (ELI Beamlines).
- 5) Applications: Microelectronics industry (CMOS, bipolar, III/V), mid-wave infrared detectors

WWW: <http://femto.nmsu.edu>

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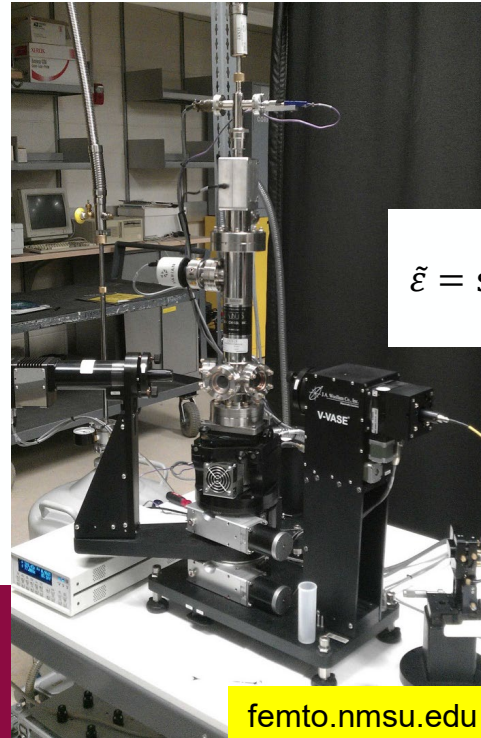
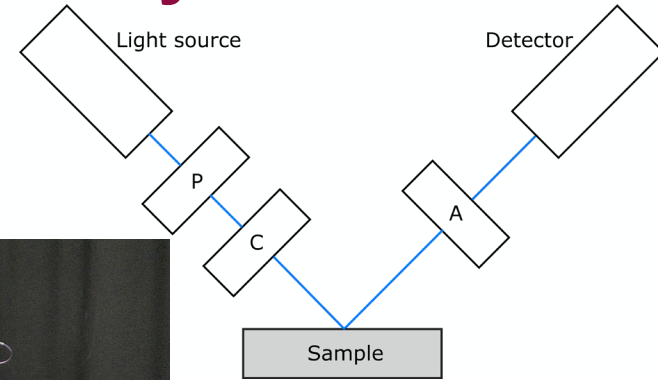
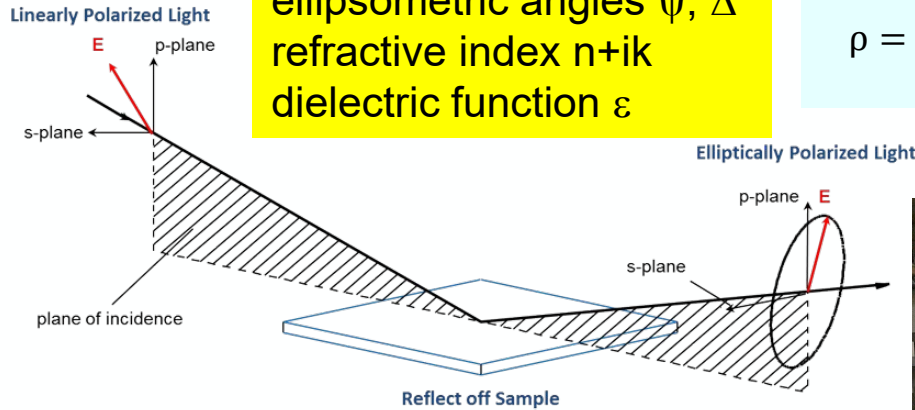
## 10th International Conference on Spectroscopic Ellipsometry

June 8-13, 2025, in Boulder, CO, USA

# Spectroscopic ellipsometry

ellipsometric angles  $\psi$ ,  $\Delta$   
 refractive index  $n+ik$   
 dielectric function  $\epsilon$

$$\rho = \frac{r_p}{r_s} = \tan \Psi e^{i\Delta}$$

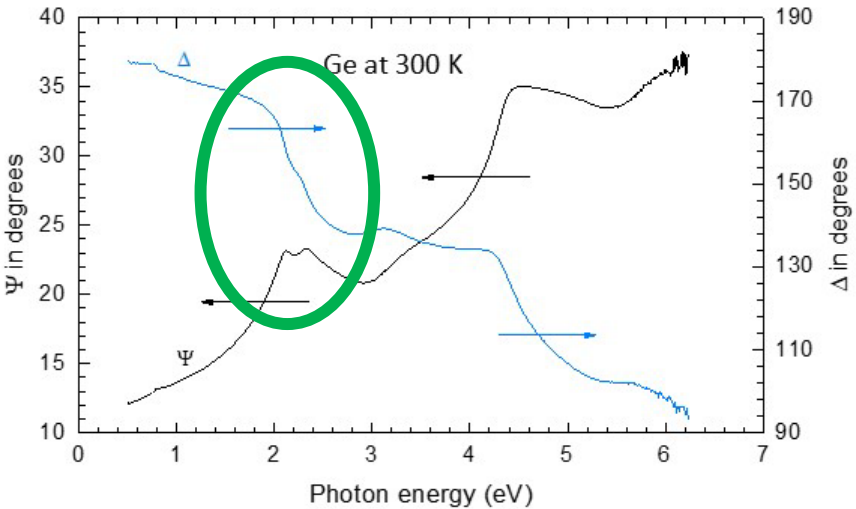


$$\epsilon = \sin^2 \varphi \left[ 1 + \tan^2 \varphi \cdot \left( \frac{1 - \rho}{1 + \rho} \right)^2 \right]$$

UHV cryostat  
 & V-VASE  
 ellipsometer

Tompkins & Hilfiker,  
 Spectroscopic  
 Ellipsometry (2016)

femto.nmsu.edu



# Ellipsometry at NMSU

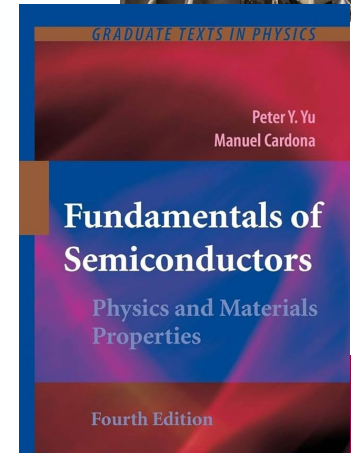
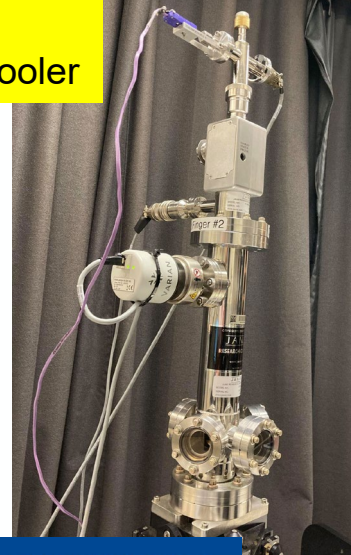
diamond windows  
closed-cycle He cooler



Ellipsometry on anything (inorganic, 3D)

- Metals, insulators, semiconductors
- Mid-IR to vacuum UV (150 nm to 40  $\mu\text{m}$ )
- **10 to 800 K, ultrafast ellipsometry**

Ellipsometry tells us a lot about materials quality (not necessarily what we want to know).



Optical critical points of thin-film  $\text{Ge}_{1-y}\text{Sn}_y$  alloys: A comparative  $\text{Ge}_{1-y}\text{Sn}_y / \text{Ge}_{1-x}\text{Si}_x$  study

445

2006

VR D'costa, CS Cook, AG Birdwell, CL Littler, M Canonico, S Zollner, ...  
Physical Review B—Condensed Matter and Materials Physics 73 (12), 125207

Growth and strain compensation effects in the ternary  $\text{Si}_{1-x-y}\text{Ge}_x\text{C}_y$  alloy system

397

1992

K Eberl, SS Iyer, S Zollner, JC Tsang, FK LeGoues  
Applied physics letters 60 (24), 3033-3035

Ge–Sn semiconductors for band-gap and lattice engineering

341

2002

M Bauer, J Taraci, J Tolle, AVG Chizmeshya, S Zollner, DJ Smith, ...  
Applied physics letters 81 (16), 2992-2994

<http://femto.nmsu.edu>



# Problem statement: optical constants

- (1) Achieve a **quantitative** understanding of **photon absorption** and **emission** processes.
  - Our **qualitative** understanding of excitonic absorption is 50-100 years old (Einstein coefficients),
  - But **insufficient** for modeling of detectors and emitters.
- (2) How are optical processes affected by high carrier concentrations (**screening**)?
  - High carrier densities can be achieved with
    - In situ doping (Menendez, Kouvetakis)
    - **high temperatures (narrow-gap or gapless semiconductors)**
    - **ultrafast (femtosecond) lasers**
  - **Application:** CMOS-integrated mid-infrared camera (thermal imaging with a phone).

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## 10th International Conference on Spectroscopic Ellipsometry

June 8-13, 2025, in Boulder, CO, USA

# Application: Midwave Infrared Detectors Germanium-Tin Alloys

Intensity of Optical Absorption by Excitons

R. J. Elliott

Phys. Rev. **108**, 1384 – Published 15 December 1957

Article

References

Citing Articles (1,780)

PDF

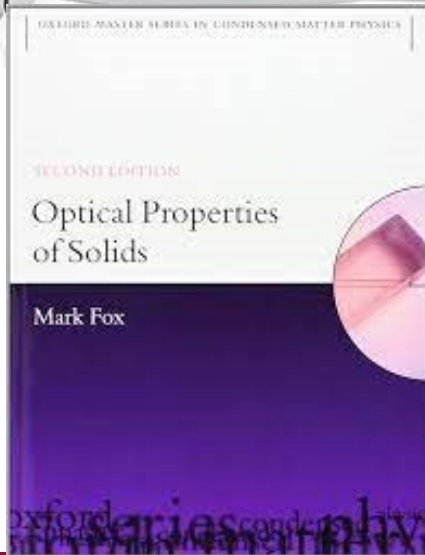
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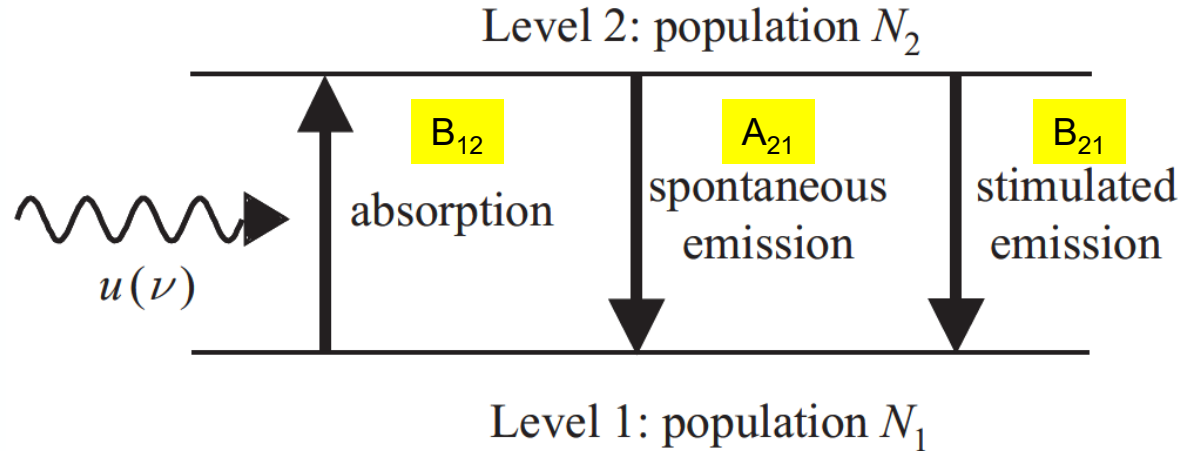
## ABSTRACT

The intensity of optical absorption close to the edge in semiconductors is examined using band theory together with the effective-mass approximation for the excitons. Direct transitions which occur when the band extrema on either side of the forbidden gap are at the same  $\mathbf{K}$ , give a line spectrum and a continuous absorption of characteristically different form and intensity, according as transitions between band states at the extrema are allowed or forbidden. If the extrema are at different  $\mathbf{K}$  values, indirect transitions involving phonons occur, giving absorption proportional to  $(\Delta E)^{\frac{1}{2}}$  for each exciton band, and to  $(\Delta E)^2$  for the continuum. The experimental results on  $\text{Cu}_2\text{O}$  and Ge are in good qualitative agreement with direct forbidden and indirect transitions, respectively.

Received 9 April 1957



# Einstein coefficients



One coefficient is sufficient:

$$g_1 B_{12} = g_2 B_{21}$$

$$A_{21} = \frac{2\hbar\omega^3}{\pi c^3} B_{21}$$

Use Fermi's Golden Rule  
to calculate  $B_{12}$

In equilibrium:  $N_1, N_2$  constant.  
Absorption and emission balance.  
Black-body radiation  $u(\hbar\omega)$

$$B_{12}N_1u(\hbar\omega) = A_{21}N_2 + B_{21}N_2u(\hbar\omega)$$

# Fermi's Golden Rule: Tauc plot

Direct band gap absorption

$$\frac{1}{\tau} = \frac{2\pi}{\hbar} \int_{i,f} |\langle f | H_{eR} | i \rangle|^2 \delta(E_f - E_i - \hbar\omega) = \frac{2\pi}{\hbar} |\langle f | H_{eR} | i \rangle|^2 g_{fi}(\hbar\omega)$$

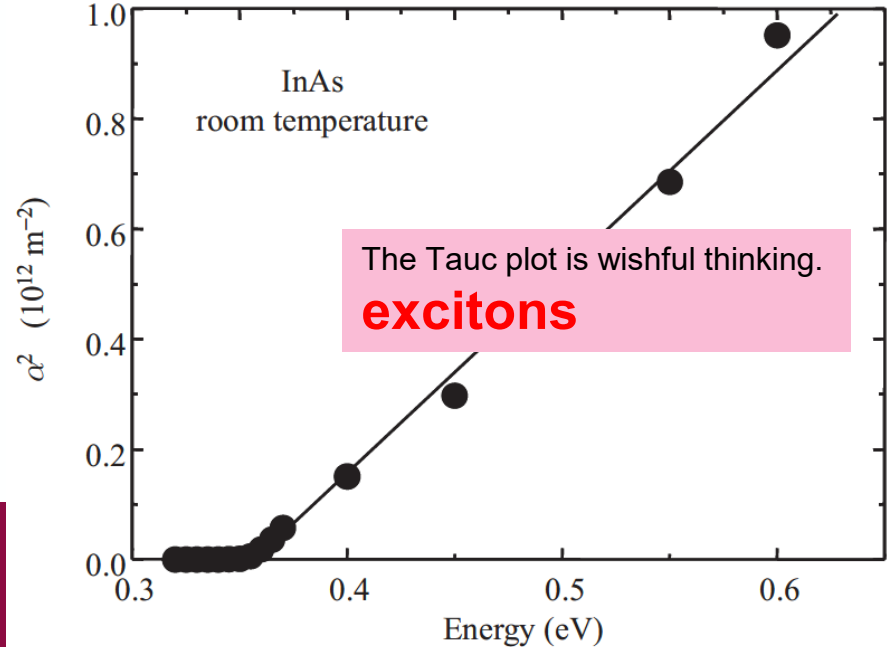
$$\langle f | H_{eR} | i \rangle = \frac{e}{m_0} \langle f | \vec{p} | i \rangle \cdot \vec{A}_0$$

Use  $\mathbf{k} \cdot \mathbf{p}$  matrix element  $P$ :  $E_p = 2P^2/m_0$

$$\varepsilon_2(\hbar\omega) = \frac{e^2 \sqrt{m_0} \mu^{\frac{3}{2}} E_p \sqrt{E_0}}{3\pi \sqrt{2} \varepsilon_0 \hbar (\hbar\omega)^2} \sqrt{\frac{\hbar\omega}{E_0} - 1}$$

constant  $\mathbf{k} \cdot \mathbf{p}$  matrix element

Joint DOS  
parabolic bands





# Fermi's Golden Rule: Tauc plot



Melissa Rivero Arias

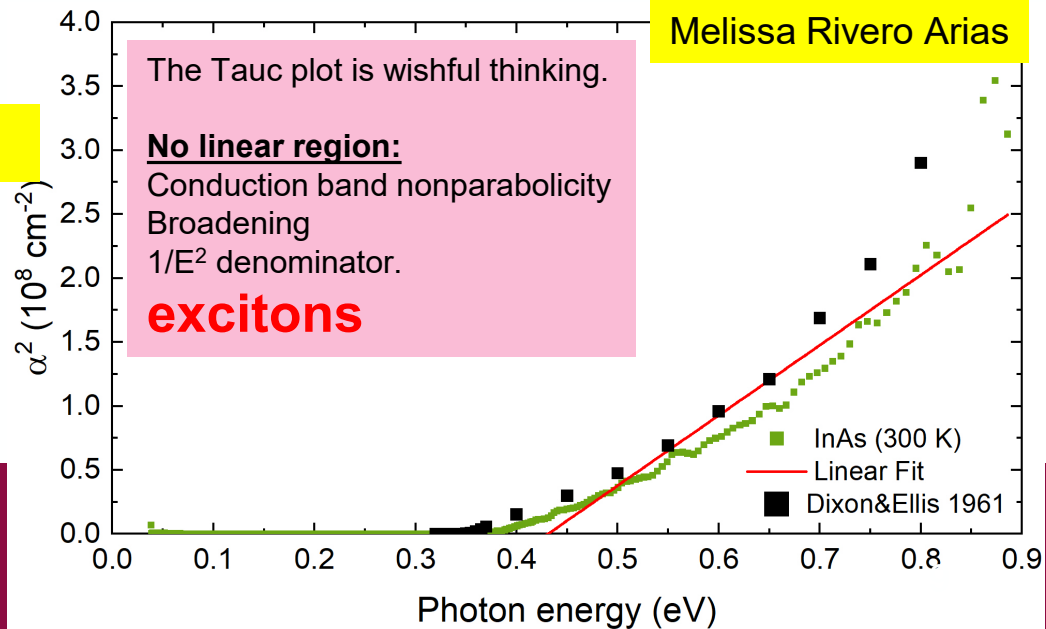
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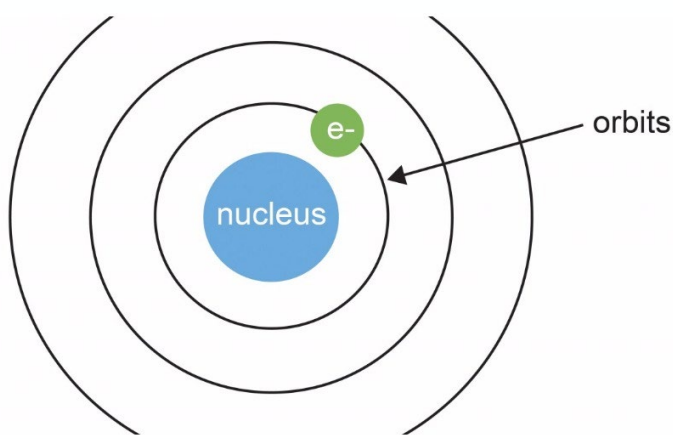
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# Bohr model for free excitons



Electron and hole form a bound state with binding energy.

$$E(n) = -\frac{\mu}{m_0} \frac{1}{\epsilon_r^2} \frac{R_H}{n^2} = -\frac{R}{n^2}$$

$R_H = 13.6$  eV Rydberg energy.  
QM mechanical treatment easy.

1. Reduced electron/hole mass

(**optical mass**)

$$\frac{1}{\mu} = \frac{1}{m_e} + \frac{1}{m_h}$$

2. **Static screening** with static dielectric constant  $\epsilon_r$ .

3. **Exciton radius:**

$$a_n = \frac{m_0}{\mu} \epsilon_r n^2 a_H$$

$$a_H = 0.53 \text{ \AA}$$

4. Excitons **stable** if  $R \gg kT$

5. Exciton **momentum** is zero.

6. **Exciton enhancement important even if  $R \ll kT$  (high temperature).**

# Sommerfeld enhancement (3D)

Excitonic Rydberg energy

$$R = \frac{\mu}{m_0 \epsilon_r^2} R_H$$

Discrete states

$$E_n = E_g - \frac{1}{n^2} R_X$$

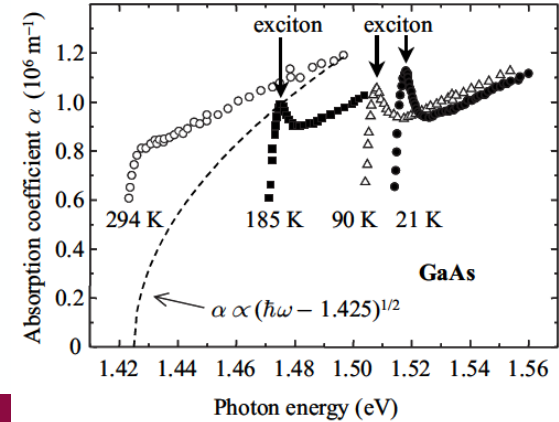
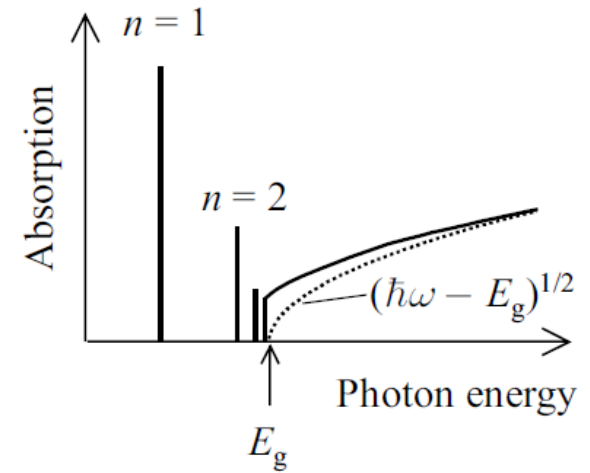
Discrete absorption

$$\epsilon_2(E) = \frac{8\pi |P|^2 \mu^3}{3\omega^2 (4\pi\epsilon_0)^3 \epsilon_r^3} \sum_{n=1}^{\infty} \frac{1}{n^3} \delta(E - E_n)$$

Continuum absorption

$$\epsilon_2(E) = \frac{2|P|^2 (2\mu)^{3/2} \sqrt{E - E_0}}{3\omega^2} \frac{\xi e^{\xi}}{\sinh \xi}$$

$$\xi = \pi \sqrt{R/E - E_0}$$



Use Bohr wave functions to calculate  $\epsilon_2$ .  
Toyozawa discusses broadening.

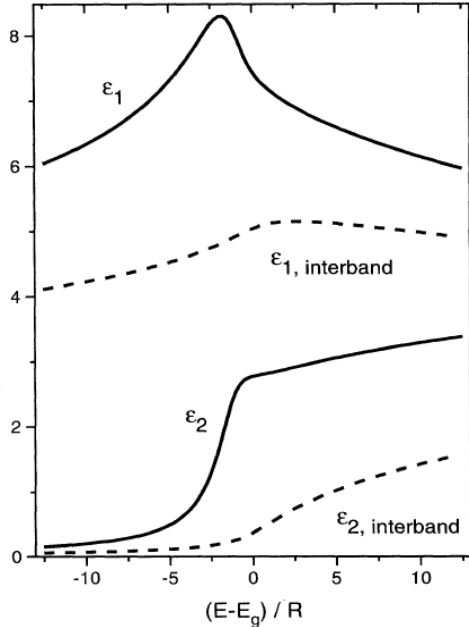
R. J. Elliott, Phys. Rev. **108**, 1384 (1957)  
Yu & Cardona; Fox, Chapter 4; Tanguy 1995

# Elliott-Tanguy exciton absorption

Direct band gap absorption

Excitonic binding energy:  $R=R_H \times \mu_h / \epsilon_s^2$

$$\epsilon_2(\hbar\omega) = \frac{e^2 \sqrt{m_0} \mu^{\frac{3}{2}} E_P \sqrt{R}}{3\pi \sqrt{2} \epsilon_0 \hbar (\hbar\omega)^2} \left[ \sum_{n=1}^{\infty} \frac{4\pi R}{n^3} \delta\left(\hbar\omega - E_0 + \frac{R}{n^2}\right) + \frac{2\pi H(\hbar\omega - E_0)}{1 - \exp\left(-2\pi \sqrt{R/\hbar\omega - E_0}\right)} \right]$$

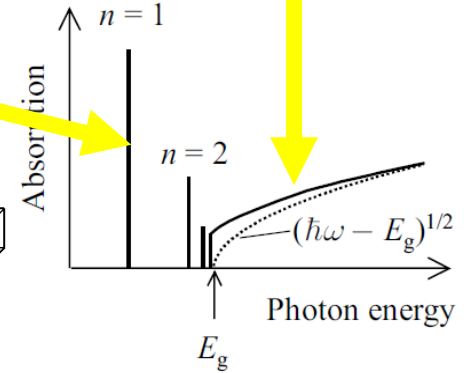
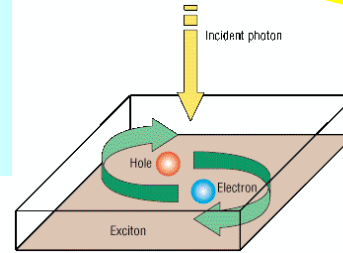


bound excitons

exciton continuum enhancement

Tanguy's contributions:

- Add Lorentzian broadening
- Kramers-Kronig transform to get the real part.



R. J. Elliott, Phys. Rev. **108**, 1384 (1957).

Christian Tanguy, Phys. Rev. Lett. **75**, 4090 (1995) + (E)

... the Future.



# Intensity of Optical Absorption by Excitons

R. J. Elliott

Phys. Rev. **108**, 1384 – Published 15 December 1957

Article

References

Citing Articles (1,780)

PDF

Export Citation



## ABSTRACT

The intensity of optical absorption close to the edge in semiconductors is examined using band theory together with the effective-mass approximation for the excitons. Direct transitions which occur when the band extrema on either side of the forbidden gap are at the same  $\mathbf{K}$ , give a line spectrum and a continuous absorption of characteristically different form and intensity, according as transitions between band states at the extrema are allowed or forbidden. If the extrema are at different  $\mathbf{K}$  values, indirect transitions involving phonons occur, giving absorption proportional to  $(\Delta E)^{\frac{1}{2}}$  for each exciton band, and to  $(\Delta E)^2$  for the continuum. The experimental results on  $\text{Cu}_2\text{O}$  and Ge are in good qualitative agreement with direct forbidden and indirect transitions, respectively.

Received 9 April 1957

# Elliott-Tanguy theory applied to Ge

## • Fixed parameters:

- Electron and hole masses (temperature dependent)
- Excitonic binding energy  $R$
- Amplitude  $A$  (derived from matrix element  $P$ )

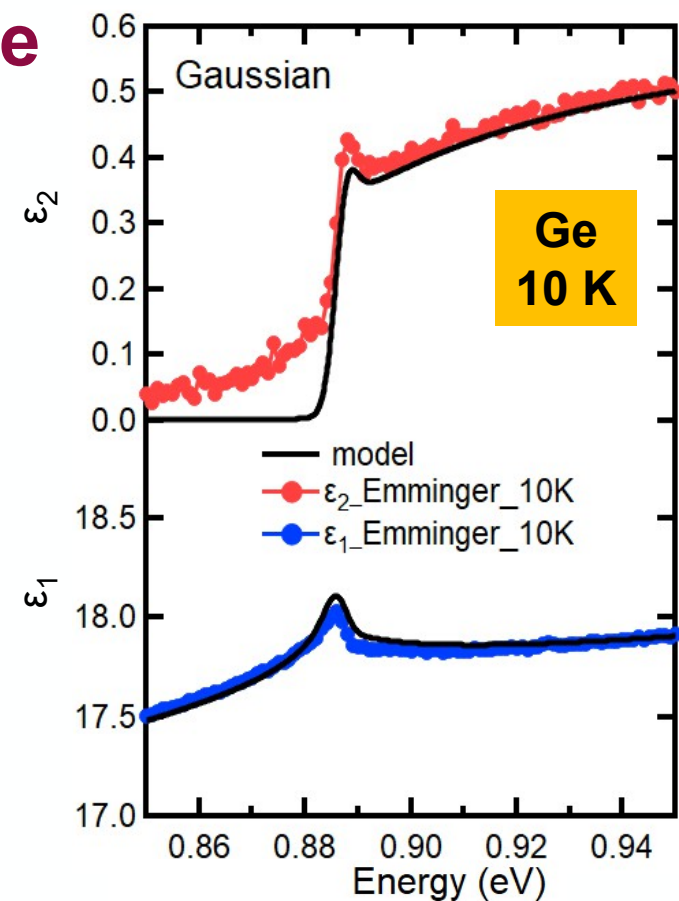
## • Adjustable parameters:

- Broadening  $\Gamma$ : 2.3 meV
- Band gap  $E_0$
- Linear background  $A_1$  and  $B_1$   
(contribution from  $E_1$  to real part of  $\epsilon$ )

## • Problems:

- Broadening below the gap (band tail, oxide correction)

Quantitative agreement



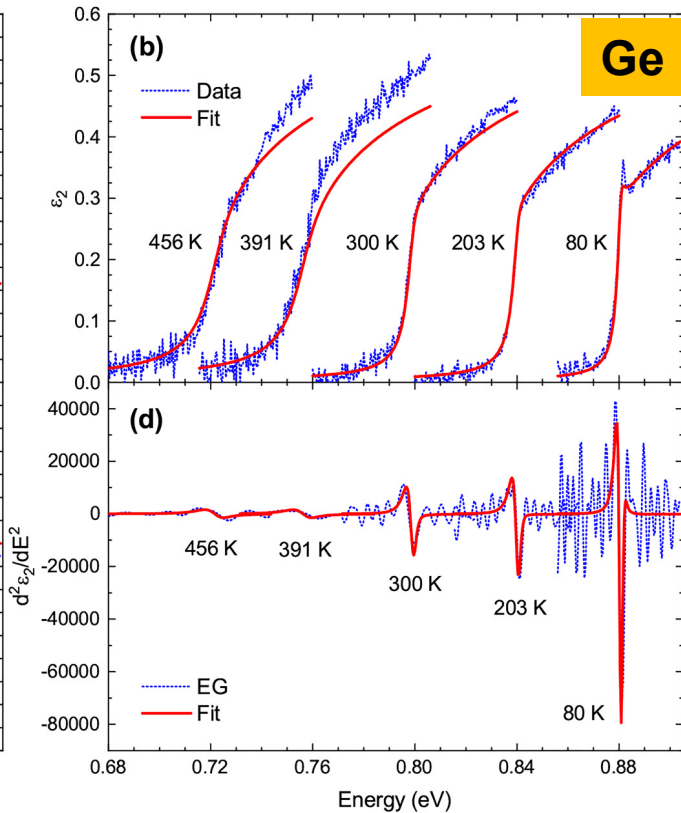
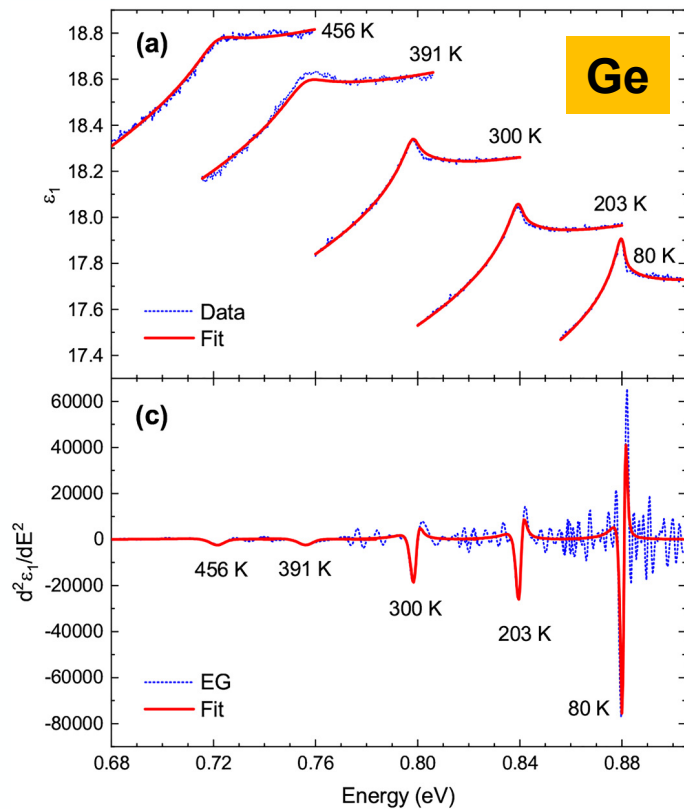
# Elliott-Tanguy theory applied to Ge

Good agreement at low temperatures.

Model also describes second derivatives.

## Potential problems:

- Matrix element  $k$ -dependent
- Nonparabolicity
- Resonant indirect absorption
- ??? at high T.



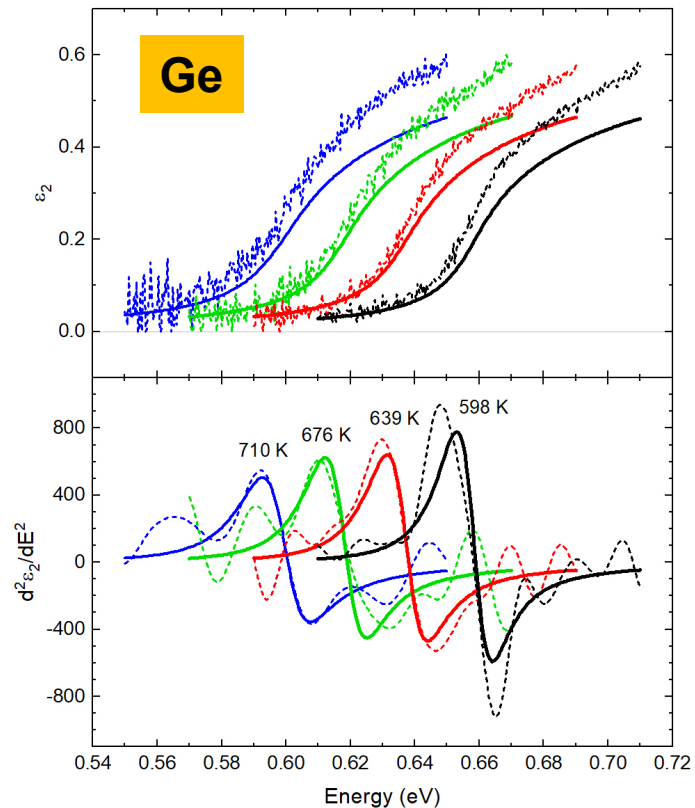
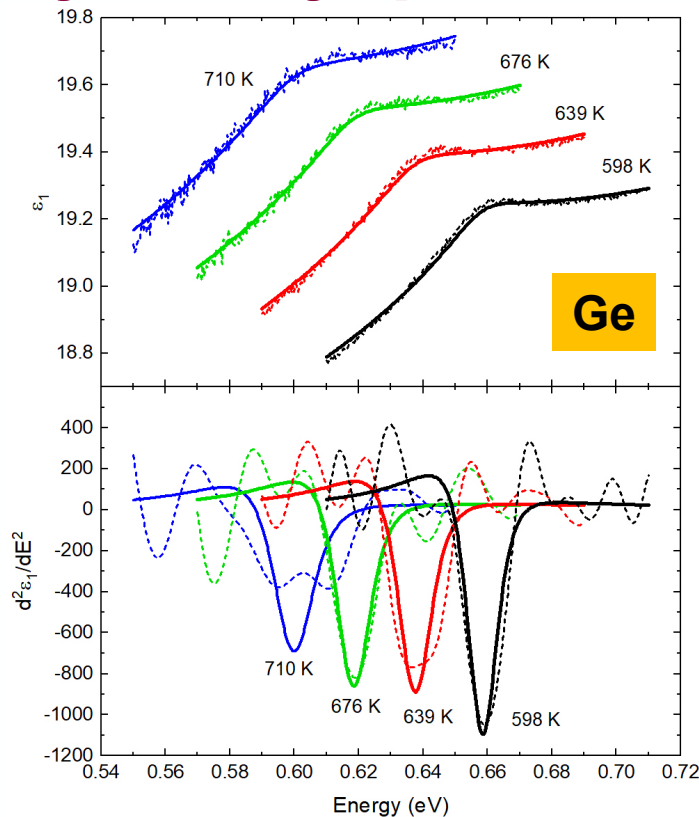
# Elliott-Tanguy theory: problems for Ge at high T

Good agreement at low temperatures.

Model also describes second derivatives.

## Potential problems:

- Matrix element  $k$ -dependent
- Nonparabolicity
- Resonant indirect absorption
- **Temperature dependence of the effective mass.**





# Temperature dependence of the effective mass

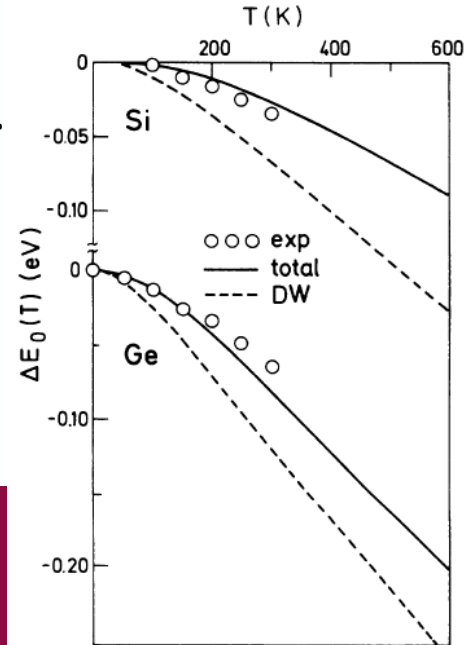
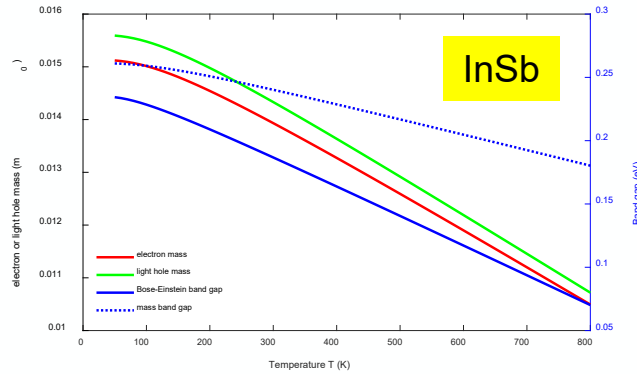
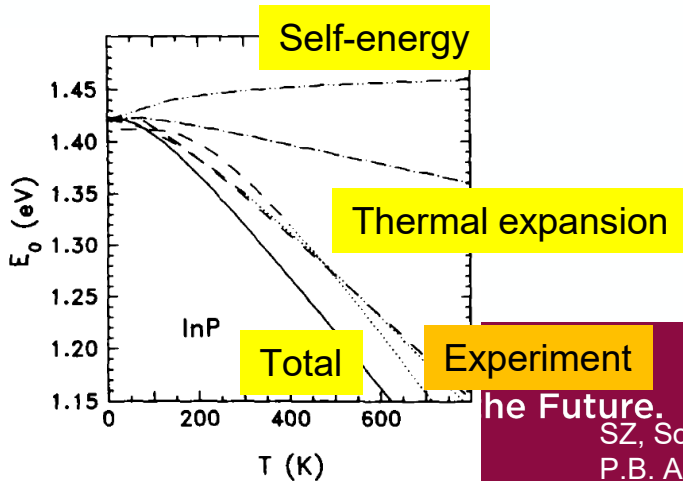
- Effective electron mass given by k·p theory

$$\frac{1}{m_e(T)} = 1 + \frac{E_P}{3} \left( \frac{2}{E_0(T)} + \frac{1}{E_0(T) + \Delta_0} \right)$$

$E_0$ : direct band gap

k·p matrix element  $P$ :  $E_P = 2P^2/m_0$

- Temperature dependence of the direct band gap has two contributions:
  - Thermal expansion of the lattice
  - Electron-phonon interaction (Debye-Waller term and self-energy)
- “Mass band gap” should **only include the thermal expansion**.



the Future.

SZ, Solid State Commun. **77**, 485 (1991).

P.B. Allen and M. Cardona, Phys. Rev. B **27** 4760 (1983).

# Two-dimensional saddle-point excitons ( $E_1$ , $E_1 + \Delta_1$ )

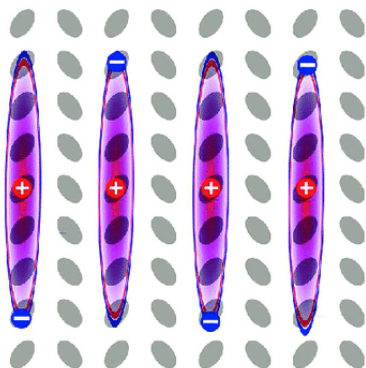
$$\varepsilon(E) = \frac{A}{(E + i\Gamma)^2} \{g[\xi(E + i\Gamma)] + g[\xi(-E - i\Gamma)] - 2g[\xi(0)]\}$$

$$g(\xi) = 2\ln(\xi) - 2\psi\left(\frac{1}{2} - \xi\right)$$

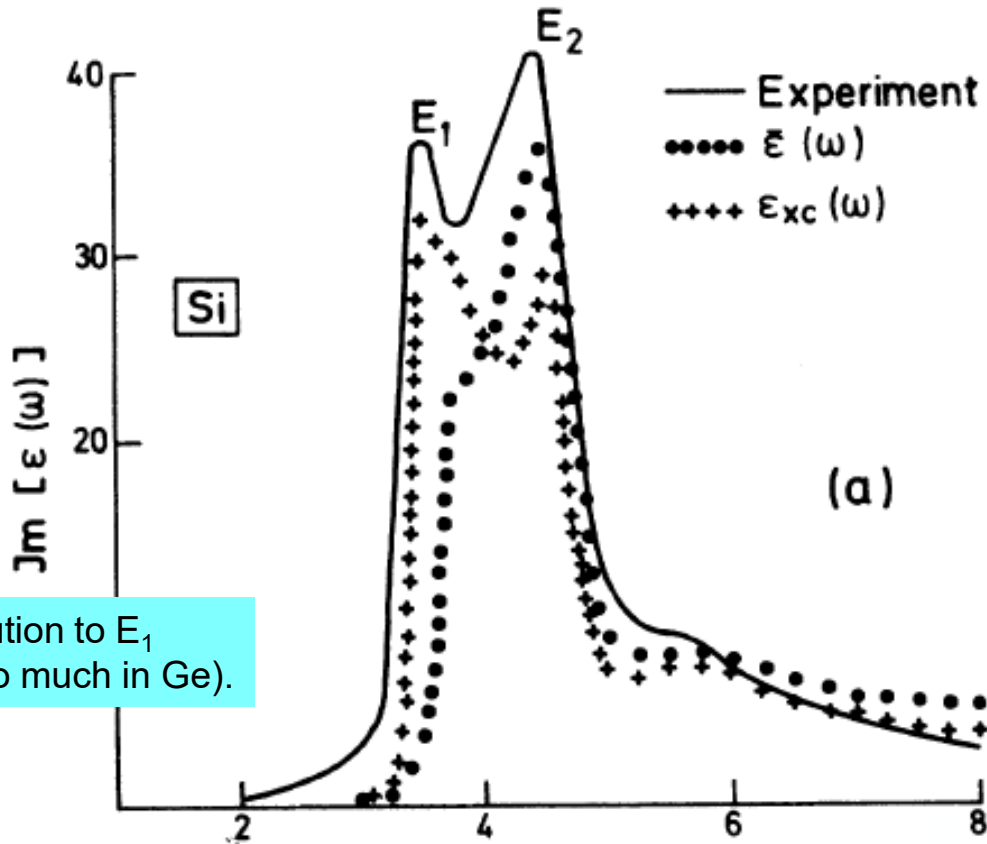
$$\psi(z) = \frac{d\ln\Gamma(z)}{dz}$$

$$\xi(z) = \sqrt{R/E_0 - z}$$

$$A = \frac{\mu e^2}{3\pi\varepsilon_0 m_0^2} |P|^2$$



Strong excitonic contribution to  $E_1$  critical point in Si (not so much in Ge).



B. Velicky and J. Sak, *phys. status solidi* **16**, 147 (1966)  
 W. Hanke and L.J. Sham, *Phys. Rev. B* **21**, 4656 (1980)  
 C. Tanguy, *Solid State Commun.* **98**, 65 (1996)

# Two-dimensional Bohr problem

$$H = -\frac{\hbar^2}{2\mu_{\perp}} \left( \frac{\partial^2}{\partial x^2} + \frac{\partial^2}{\partial y^2} \right) - \frac{\hbar^2}{2\mu_{\parallel}} \frac{\partial^2}{\partial z^2} - \frac{e^2}{\epsilon_r r}$$

Assume that  $\mu_{\parallel}$  along (111) is infinite (separate term).  
 Use cylindrical coordinates.  
 Separate radial and polar variables.  
 Similar Laguerre solution as 3D Bohr problem.

$$a_X = \frac{\epsilon_r m_0}{\mu_{\perp}} a_H$$

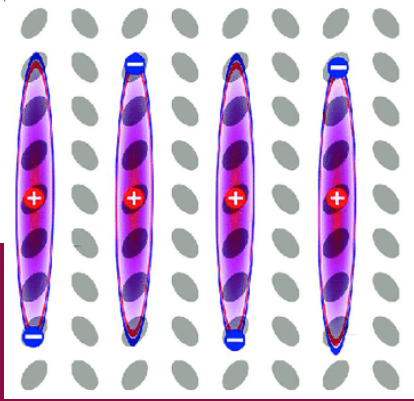
$$R = \frac{\mu_{\perp}}{m_0 \epsilon_r^2} R_H$$

$$E_n = -\frac{R}{\left(n - \frac{1}{2}\right)^2}, \quad n = 1, 2, \dots$$

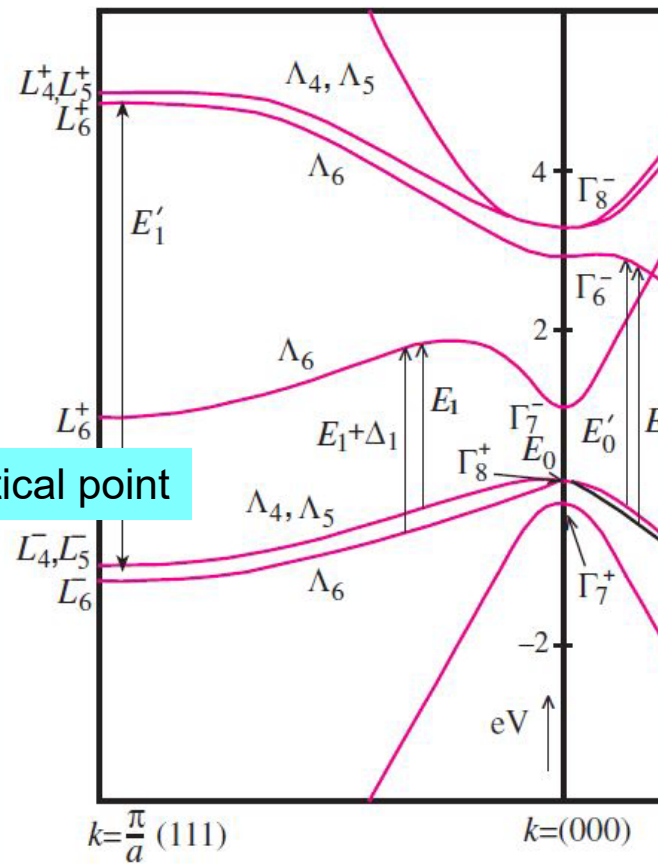
Half-integral quantum numbers

STATE BE BOLD. Shape the Future.

(same as in 3D)



2D critical point



M. Shinada and S. Sugano, J. Phys. Soc. Jpn. **21**, 1936 (1966).  
 Flügel (Rechenmethoden QM, 1952).

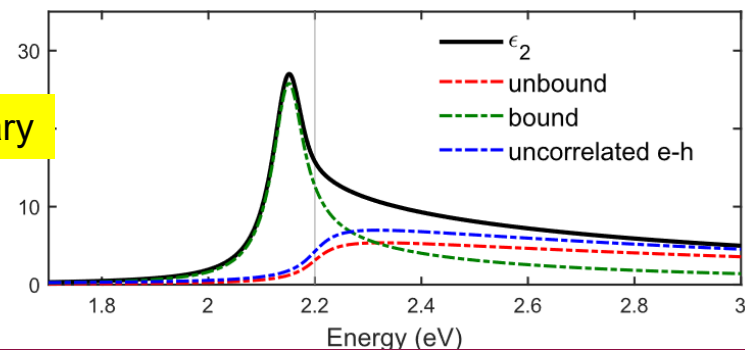
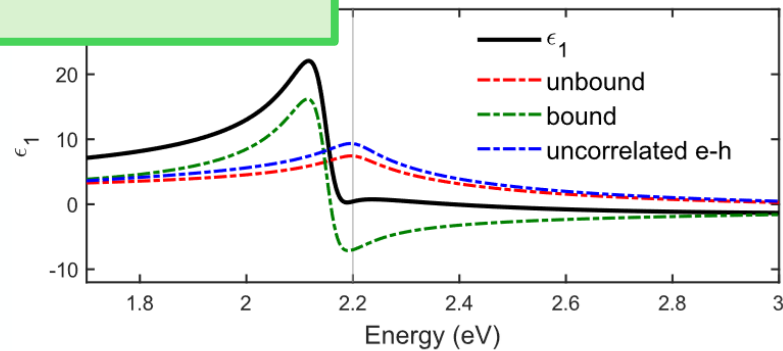
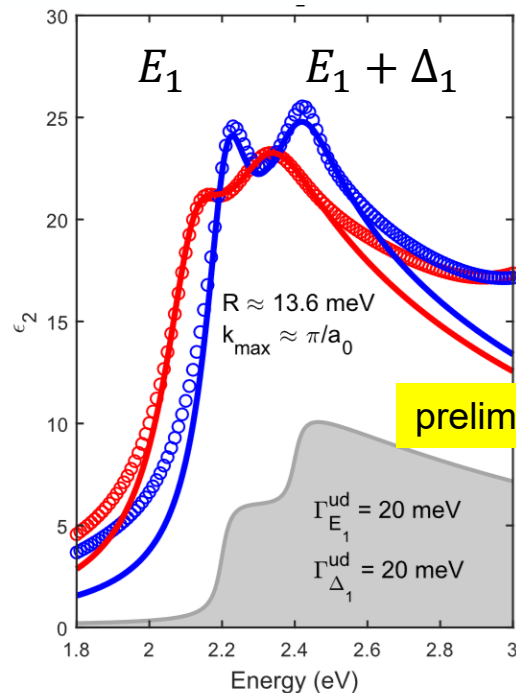
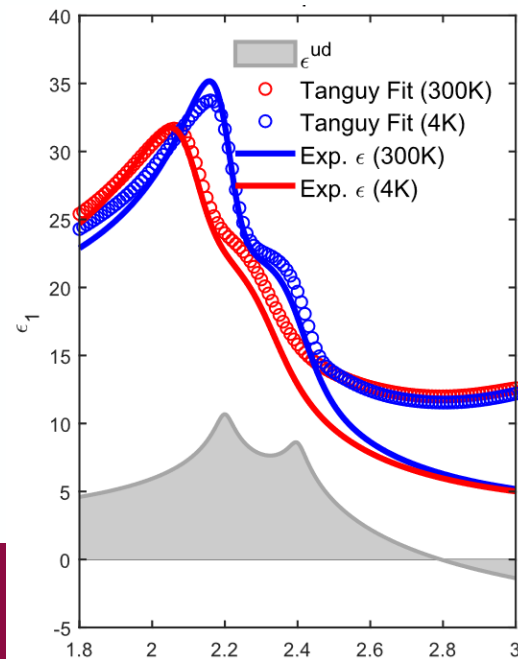
# Two-dimensional excitons at $E_1$ critical points of Ge

$$\varepsilon(E) = \frac{k_{\max} e^2 \bar{P}^2 \mu_{\perp}^{(E_1)}}{3 \varepsilon_0 m^2 \pi (E + i\Gamma)^2} \left\{ g_a \left[ \sqrt{\frac{R}{E_g - (E + i\Gamma)}} \right] + g_a \left[ \sqrt{\frac{R}{E_g - (-E - i\Gamma)}} \right] - 2g_a \left[ \sqrt{\frac{R}{E_g - (0)}} \right] \right\}$$

with

$$g_a(\xi) = 2 \ln \xi - 2 \psi(\xi)$$

Peak at  $n = 0$  for  
 $E_g - 4R$



# Problem statement: optical constants

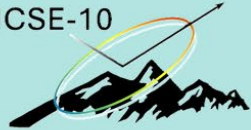
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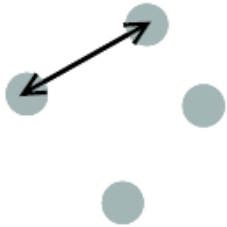
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# Condensation of excitons at high density

## Exciton gas



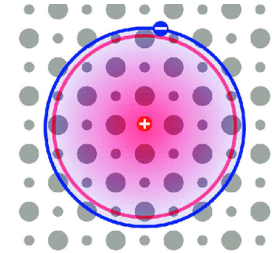
(a) Low density  
Separation  $\gg$  diameter

Mott transition (insulator-metal) when electron separation equals exciton radius.

Electron separation  $d$  for density  $N$

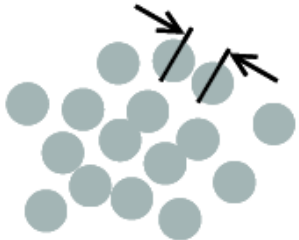
$$d = \sqrt[3]{\frac{3}{4\pi n}}$$

$$r_s = \frac{d}{a_X}$$



dimensionless

## Electron-hole liquid



(b) High density  
Separation  $\approx$  diameter

Mott transition occurs at  $r_s$  near 1.

GaAs:  $n=10^{17} \text{ cm}^{-3}$ .

Biexciton, triexciton molecule formation.

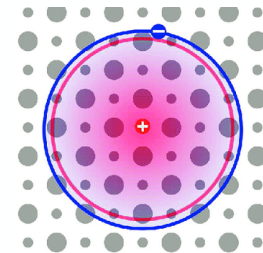
Electron-hole droplets. Bose-Einstein condensation.

# Excitons in doped or excited semiconductors

Need to include exciton screening due to doping.

Yukawa potential: Schrödinger equation not solvable.

Use Hulthen potential as an approximation



Coulomb

$$V(r) = -k \frac{1}{r}$$

$$k = \frac{e^2}{4\pi\epsilon_0\epsilon_r}$$

Debye  
screening length

Yukawa

$$V(r) = -k \frac{\exp(-r/\lambda_D)}{r}$$

$$\lambda_D = \sqrt{\frac{\epsilon_r\epsilon_0k_B T}{ne^2}} = \frac{1}{k_D}$$

Hulthen

$$V(r) = -k \frac{2/g a_X}{\exp\left(\frac{2r}{g a_X}\right) - 1}$$

$$g = \frac{\lambda_D}{a_X}$$

Unscreened:  $g = \infty$

Fully screened:  $g = 0$

Mott criterion:  $g = 1$

**Hulthen exciton** e Future.

C. Tanguy, Phys. Rev. **60**, 10660 (1999).

Banyai & Koch, Z. Phys. B **63**, 283 (1986). Haug & Koch (2009).

# Tanguy: Dielectric function of screened excitons

Bound exciton states (finite number):

$$A = \frac{\hbar^2 e^2}{6\pi\epsilon_0 m_0^2} \left(\frac{2\mu}{\hbar^2}\right)^{3/2} |P|^2$$

$$\epsilon_2(\omega) = \frac{2\pi A\sqrt{R}}{E^2} \sum_{n=1}^{n^2 < g} 2R \frac{1}{n} \left(\frac{1}{n^2} - \frac{n^2}{g^2}\right) \delta \left[ E - E_0 + \frac{R}{n^2} \left(1 - \frac{n^2}{g^2}\right)^2 \right]$$

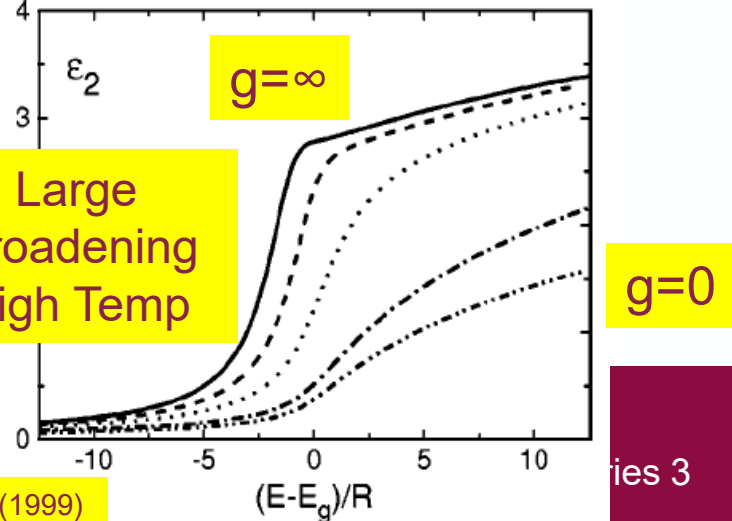
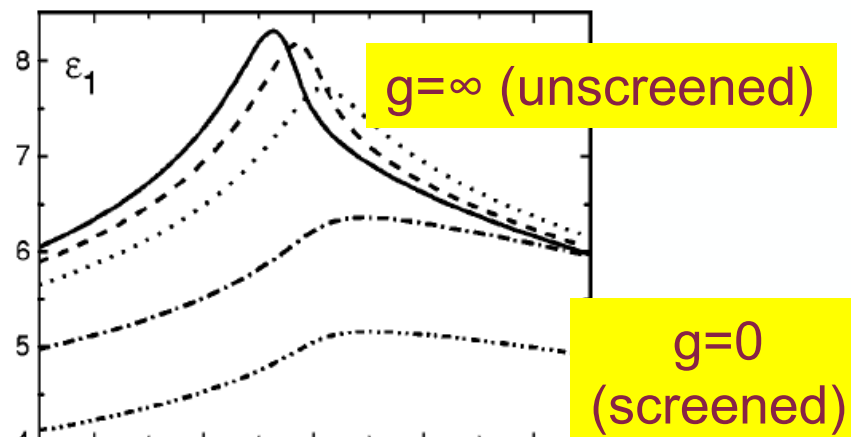
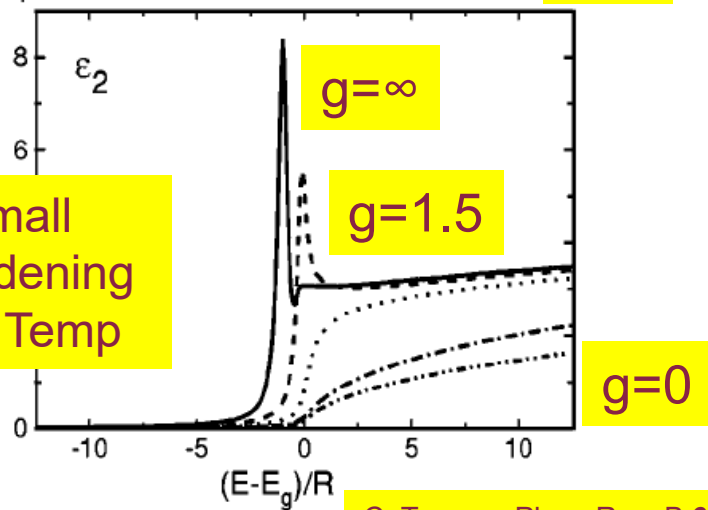
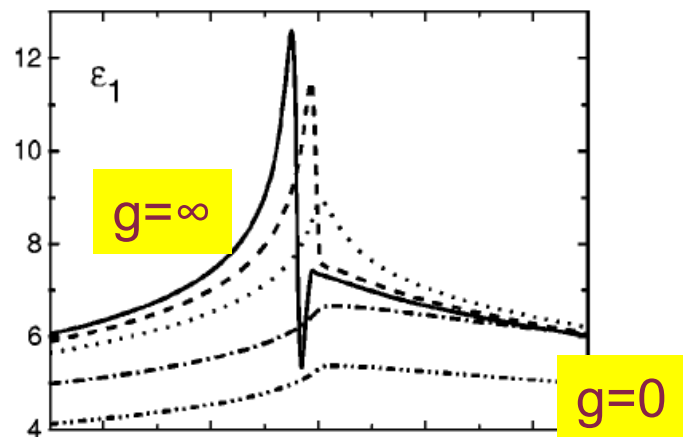
Reduced Rydberg energy

exciton continuum:

$$\epsilon_2(\omega) = \frac{2\pi A\sqrt{R}}{E^2} \frac{\sinh \pi g k}{\cosh(\pi g k) - \cosh\left(\pi g \sqrt{k^2 - \frac{4}{g}}\right)} \theta(E - E_0)$$
$$k = \pi \sqrt{(E - E_0)/R}$$

Need to introduce Lorentzian broadening and perform numerical KK transform.

# Tanguy: Dielectric function of screened excitons



# k·p theory (band structure method)

Schrödinger equation

$$H\Phi_{n\vec{k}} = \left( \frac{\vec{p}^2}{2m_0} + V \right) \Phi_{n\vec{k}} = E_{n\vec{k}} \Phi_{n\vec{k}}$$

Use Bloch's theorem:

$$\Phi_{n\vec{k}}(\vec{r}) = e^{i\vec{k}\cdot\vec{r}} u_{n\vec{k}}(\vec{r})$$

Product rule

$$(fg)'' = f''g + 2f'g' + fg''$$

Solve equation for  $\mathbf{k}=0$ .

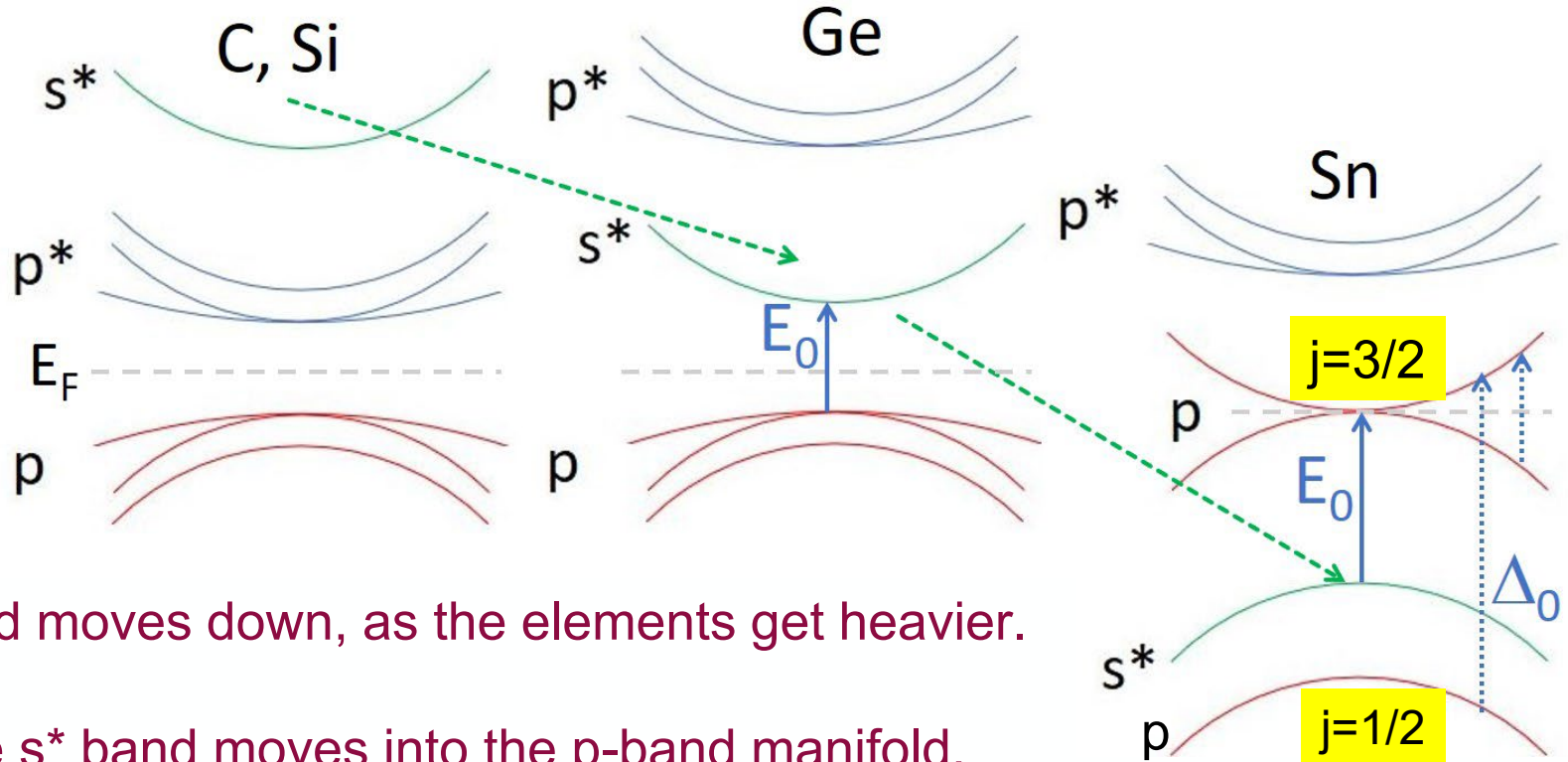
$$\left( \frac{\vec{p}^2}{2m_0} + \frac{\hbar^2 \vec{k}^2}{2m_0} + \frac{\hbar \vec{k} \cdot \vec{p}}{m_0} + V \right) u_{n\vec{k}} = E_{n\vec{k}} u_{n\vec{k}}$$

**Eliminate green free-electron term with substitution of variables (Kane 1957).**

**Then treat red term in perturbation theory.**

Works very well for semiconductors with local  $V(\mathbf{r})$  potentials.

# Relativistic Effects: Darwin Shift: C, Si, Ge, Sn



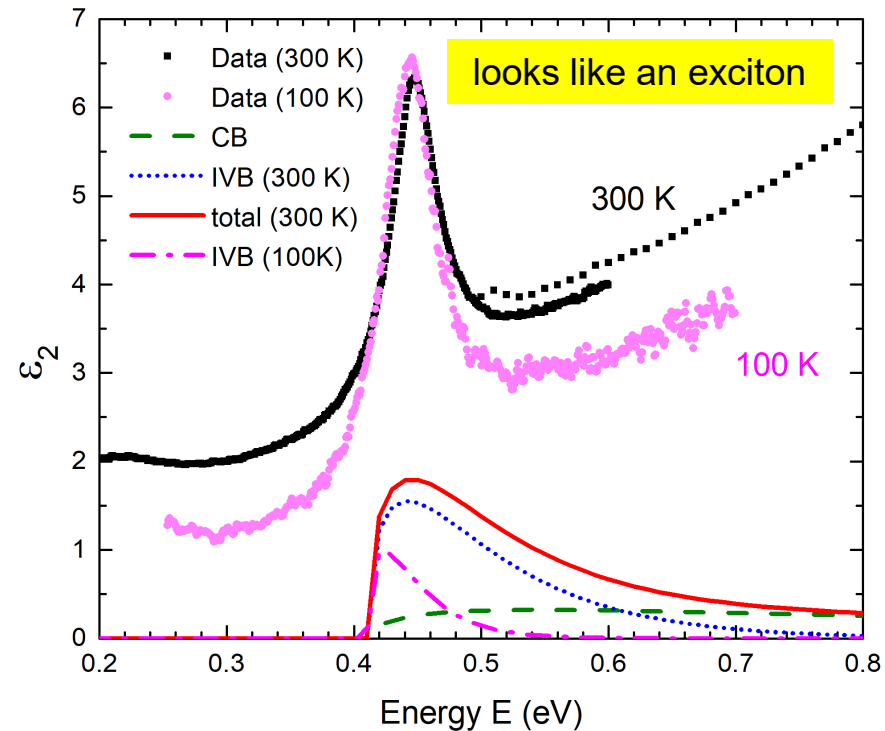
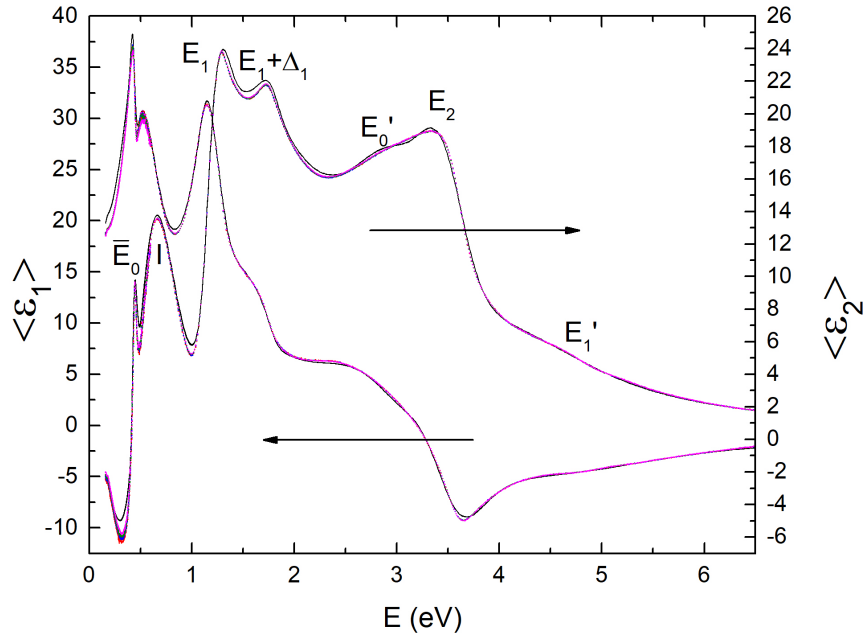
The  $s^*$  band moves down, as the elements get heavier.

In  $\alpha$ -tin, the  $s^*$  band moves into the  $p$ -band manifold, between the  $j=1/2$  and  $j=3/2$  states.

This makes  $\alpha$ -tin an (**inverted**) **gapless** semiconductor.



# Intravalence band absorption in gapless topological insulators ( $\alpha$ -tin)



R.A. Carrasco, APL **113**, 232104 (2018).

All gapless (inverted) semiconductors should have this peak. Theory with same model as Ge IVB (Kaiser 1953, Kahn 1955).

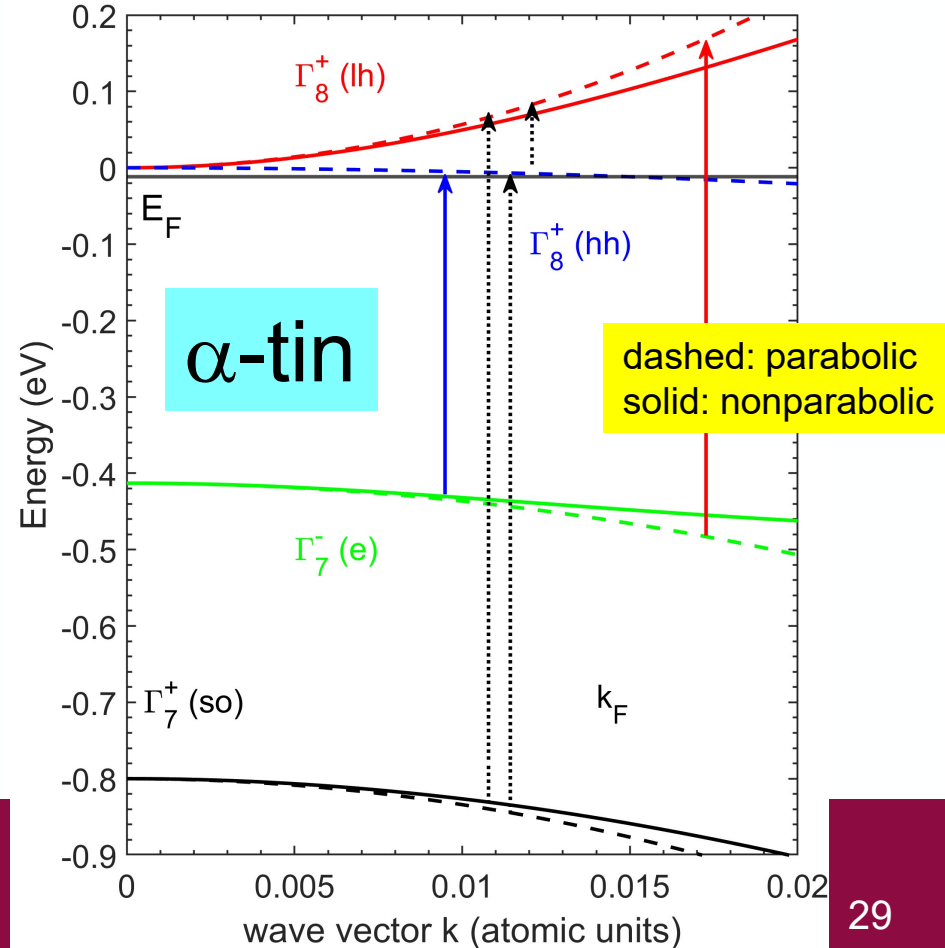
# Simple 8x8 k·p band structure of $\alpha$ -tin (Kane)

Kane 8x8 k·p Hamiltonian:

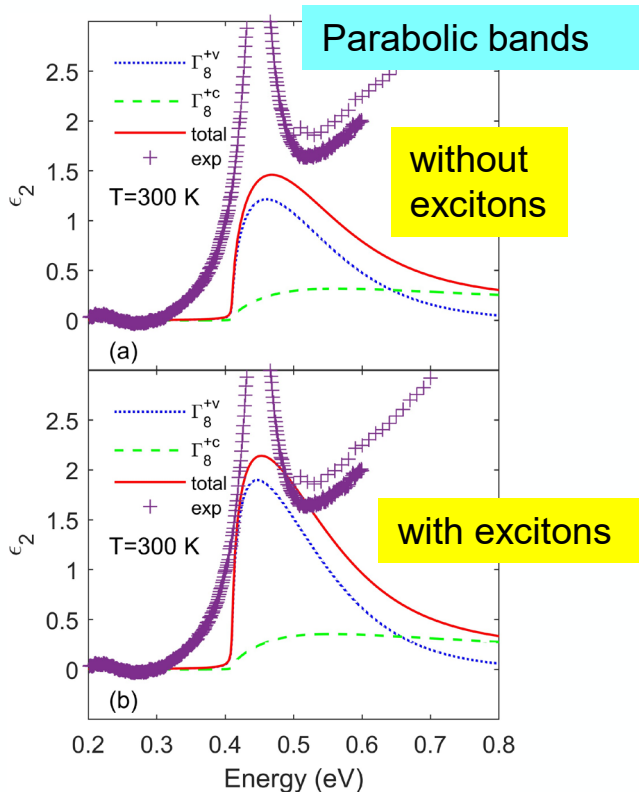
$$\tilde{H}_{\vec{k}} = \begin{pmatrix} E_0 & 0 & -\frac{\hbar\vec{k}}{m_0} iP & 0 \\ 0 & -\frac{2\Delta_0}{3} & \frac{\sqrt{2}\Delta_0}{3} & 0 \\ \frac{\hbar\vec{k}}{m_0} iP & \frac{\sqrt{2}\Delta_0}{3} & -\frac{\Delta_0}{3} & 0 \\ 0 & 0 & 0 & 0 \end{pmatrix}$$

Cubic characteristic equation:

$$\tilde{E}(\tilde{E} - E_0)(\tilde{E} + \Delta_0) - \frac{\hbar^2 k^2 E_P}{2m_0} \left( \tilde{E} + \frac{2\Delta_0}{3} \right) = 0$$



# Excitonic intravalence band absorption in $\alpha$ -tin



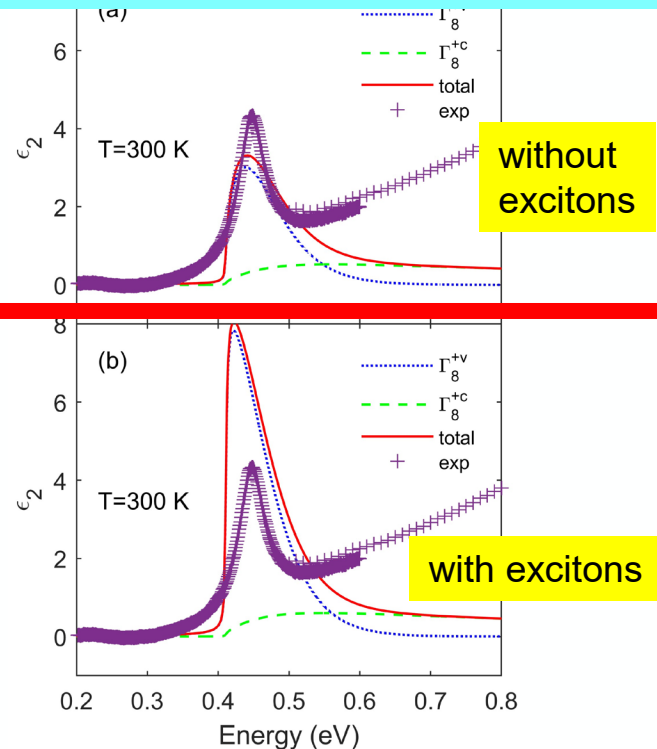
nonparabolicity affects exciton radius (screening)

Screening:

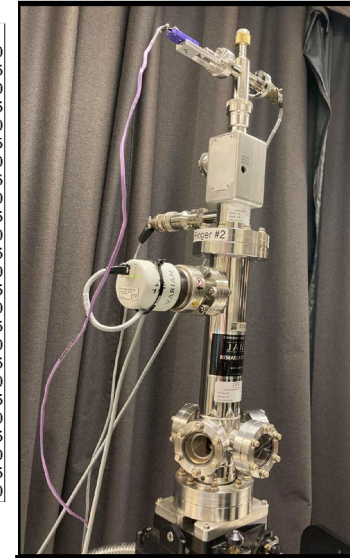
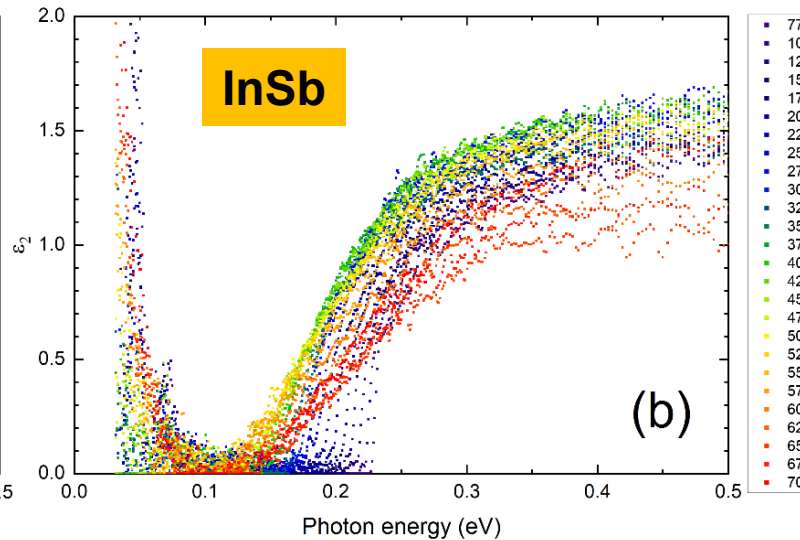
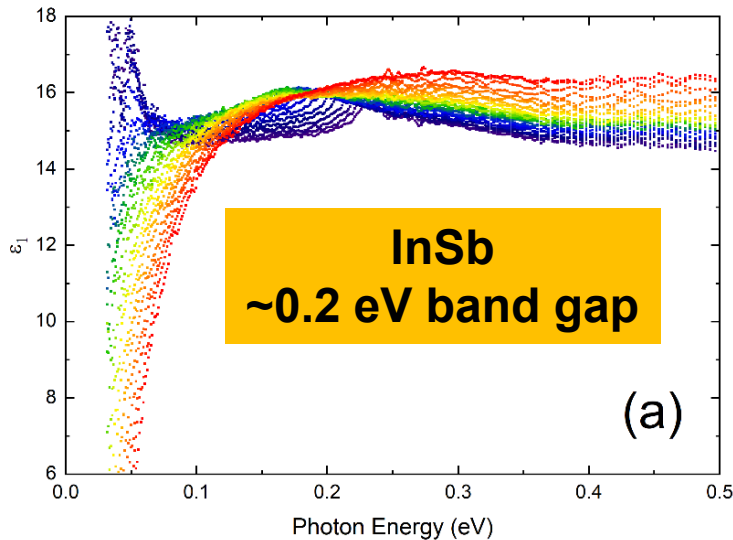
$$r_s = \frac{1}{a_x} \sqrt[3]{\frac{3}{4\pi n}}$$

$$V(r) = -k \frac{\exp(-r/\lambda_D)}{r}$$

$$\lambda_D = \sqrt{\frac{\epsilon_r \epsilon_0 k_B T}{pe^2}} = \frac{1}{k_D}$$



# Dielectric function of InSb from 80 to 800 K



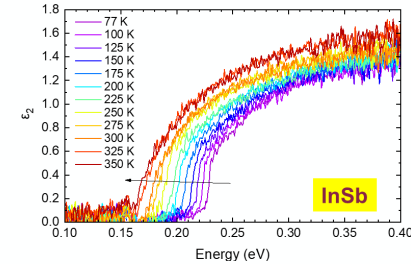
Woollam FTIR-VASE cryostat with CVD diamond windows

- **Band gap** changes with temperature (but only below 500 K).
- **Amplitude reduction at high temperatures (Pauli blocking, bleaching)**
- **Drude response** at high temperatures (thermally excited carriers).
- Depolarization artifacts at long wavelengths (below 300 K).

# Optical constants model: screened excitons

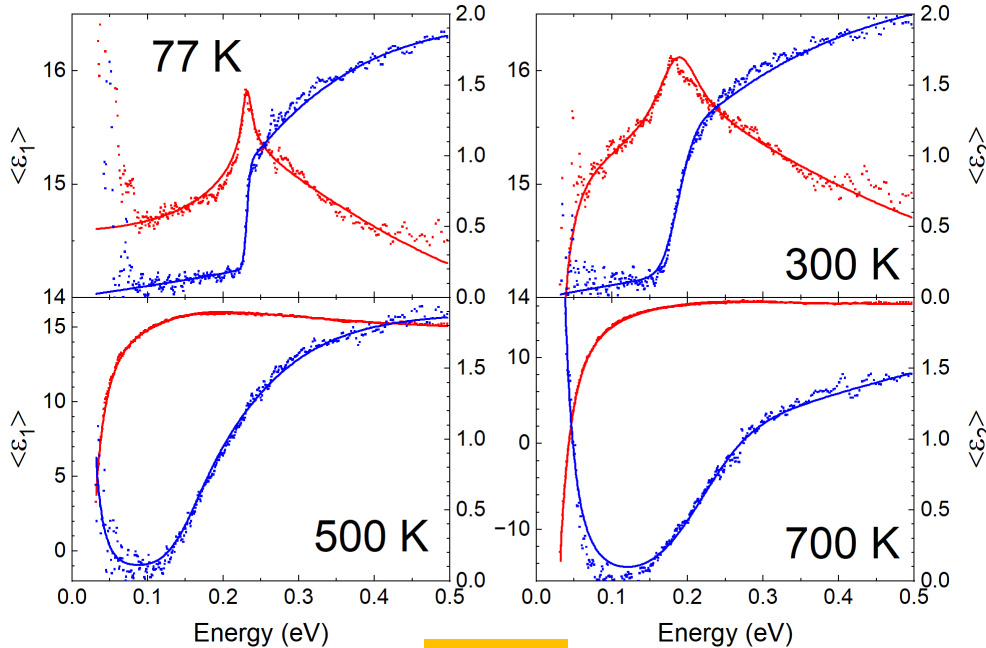
$$\varepsilon_2(E) = \frac{2\pi A\sqrt{R}}{E^2} \left\{ \sum_{n=1}^{\sqrt{g}} \frac{2R}{n} \left( \frac{1}{n^2} - \frac{n^2}{g^2} \right) \delta \left[ E - E_0 + \frac{R}{n^2} \left( 1 - \frac{n^2}{g} \right)^2 \right] + \frac{\sinh(\pi g k) H(E - E_0)}{\cosh(\pi g k) - \cosh \left( \pi g \sqrt{k^2 - \frac{4}{g}} \right)} \right\} [f_h(E) - f_e(E)]$$

- **Absorption by screened excitons** (Hulthen potential)
- **Degenerate Fermi-Dirac statistics** to calculate  $f_h$  and  $f_e$ .
- Numerical Kramers-Kronig transform (need occupation factors)
- Two terms for light and heavy excitons
- **Non-parabolicity and temperature-dependent mass** included from k.p theory
- **k-dependent matrix element  $P$ .**
- Screening parameter  $g=12/\pi^2 a_R k_{TF}$  (large: no screening)
- **Sommerfeld enhancement persists well above the Mott density.**
- **Only two free parameters: Band gap  $E_0$  and broadening  $\Gamma$**
- Amplitude  $A$  and exciton binding energy  $R$  from k.p theory and effective masses



# Band gap analysis for InSb

How does the band gap of InSb change with temperature?



**InSb**

## Parametric-Semiconductor Model:

The screenshot shows a software window titled "Parametric-Semiconductor Model". It contains a table of parameters for a fit. The table has columns for Pole #, Energy (eV), Magnitude, and other parameters. The parameters are listed as follows:

Pole #	Energy (eV)	Magnitude	Other Parameters
P1	0.2262	0.2262	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P2	4.7478	1.32	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P3	0.3115	124	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P4	0.999	788	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P5	0.84009	0.0264	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P6	1.8912	0.191	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P7	3.2469	6.56	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000
P8	1e-005	0.000568	0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000, 0.0000

Also vary "shape parameters".

Asymmetric peak shape poorly described.

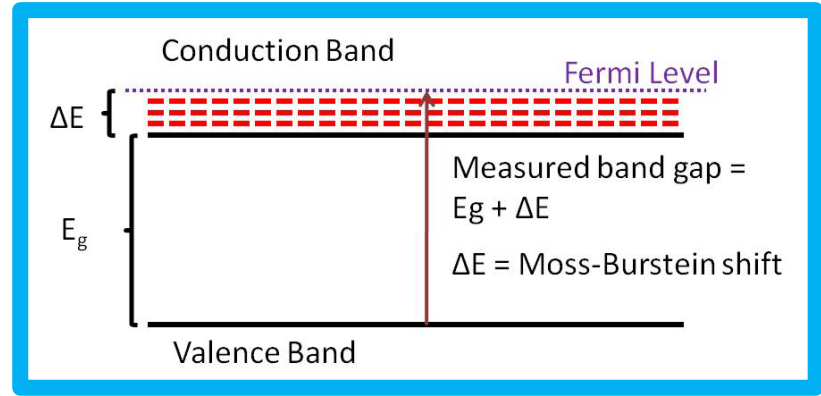
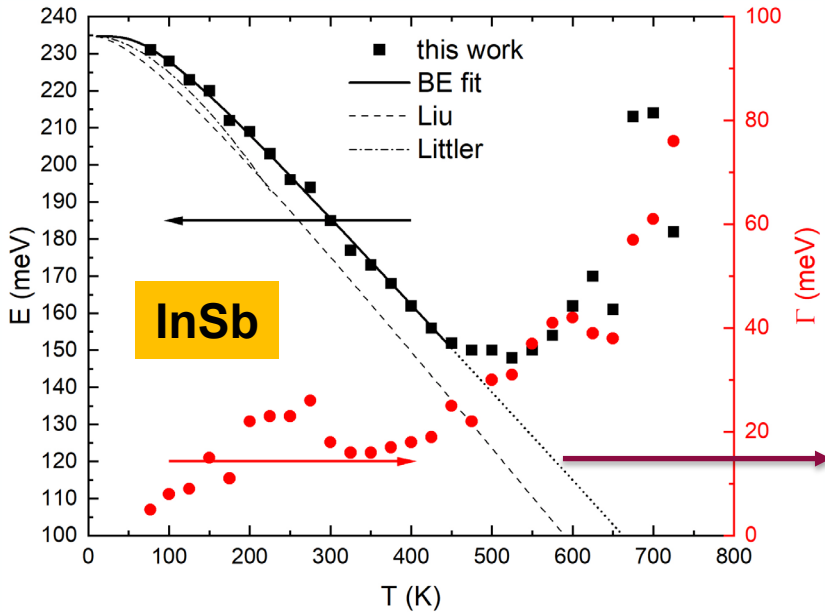
Try Tanguy oscillator for excitonic line shape.

Parameter	Final
MSE	0.2958
En0.0	0.22615 ± 0.000889
Br0.0	4.7478 ± 1.32
Am0.0	0.31415 ± 124
Disc0.0	0.999 ± 788
RPos0.0	0.84009 ± 0.0264
RAmp0.0	1.8912 ± 0.191
PoleMag.0	3.2469 ± 6.56
PoleMag2.0	1e-005 ± 0.000568





# Band gap of InSb from 80 to 800 K



## Bose-Einstein Model

$$E_0(T) = E^{\text{un}} - b \left[ 1 + \frac{2}{\exp(\Omega/k_B T)} \right]$$

- Band gap changes with temperature (but only below 500 K)
- Described by Bose-Einstein model below 500 K: Logothetidis, PRB **31**, 947 (1985).
- No redshift above 500 K: **Thermal Burstein-Moss shift**

# Nonparabolicity of InSb conduction band from k·p theory

Kane 8x8 k·p Hamiltonian:

$$\tilde{H}_{\vec{k}} = \begin{pmatrix} E_0 & 0 & -\frac{\hbar\vec{k}}{m_0} iP & 0 \\ 0 & -\frac{2\Delta_0}{3} & \frac{\sqrt{2}\Delta_0}{3} & 0 \\ \frac{\hbar\vec{k}}{m_0} iP & \frac{\sqrt{2}\Delta_0}{3} & -\frac{\Delta_0}{3} & 0 \\ 0 & 0 & 0 & 0 \end{pmatrix}$$

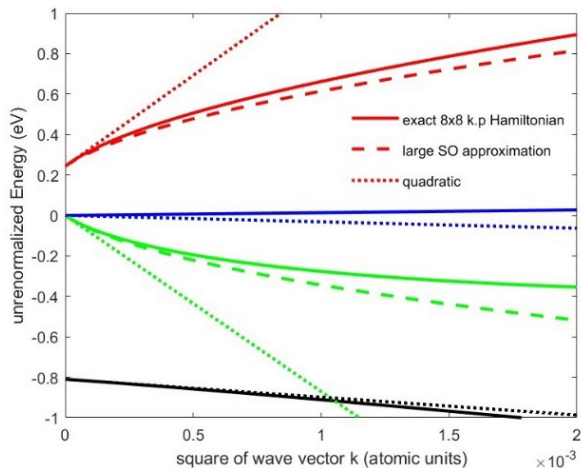
Cubic characteristic equation:

$$\tilde{E}(\tilde{E} - E_0)(\tilde{E} + \Delta_0) - \frac{\hbar^2 k^2 E_P}{2m_0} \left( \tilde{E} + \frac{2\Delta_0}{3} \right) = 0$$

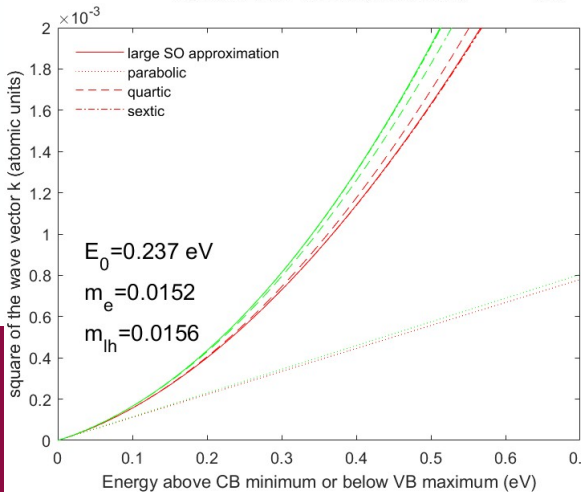
Large spin-orbit approximation:

$$E_{3,4} = \frac{\hbar^2 k^2}{2m_0} + \frac{E_0}{2} \left( 1 \pm \sqrt{1 + \frac{\hbar^2 k^2}{2m_0} \frac{2}{\mu_{lh} E_0}} \right)$$

Kane, J. Phys. Chem. Solids **1**, 249 (1957).



Energy versus k (InSb)

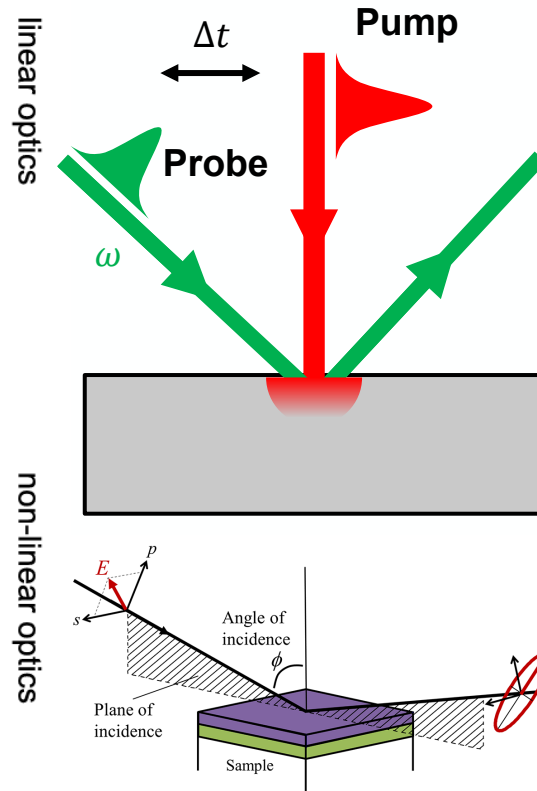
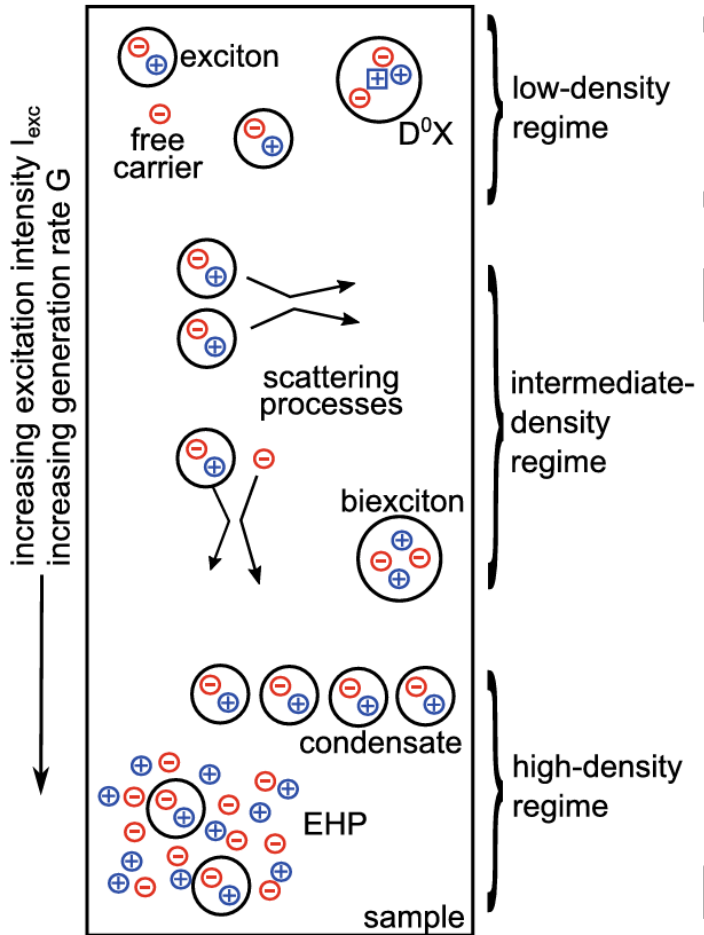


Density of CB states

$$\frac{\hbar^2 k^2}{2m_0 m^*} = \varepsilon(1 + \alpha\varepsilon + \beta\varepsilon^2)$$

$$\alpha = \frac{(1 - m^*)^2}{E_0}$$

# Femtosecond Pump-Probe Ellipsometry



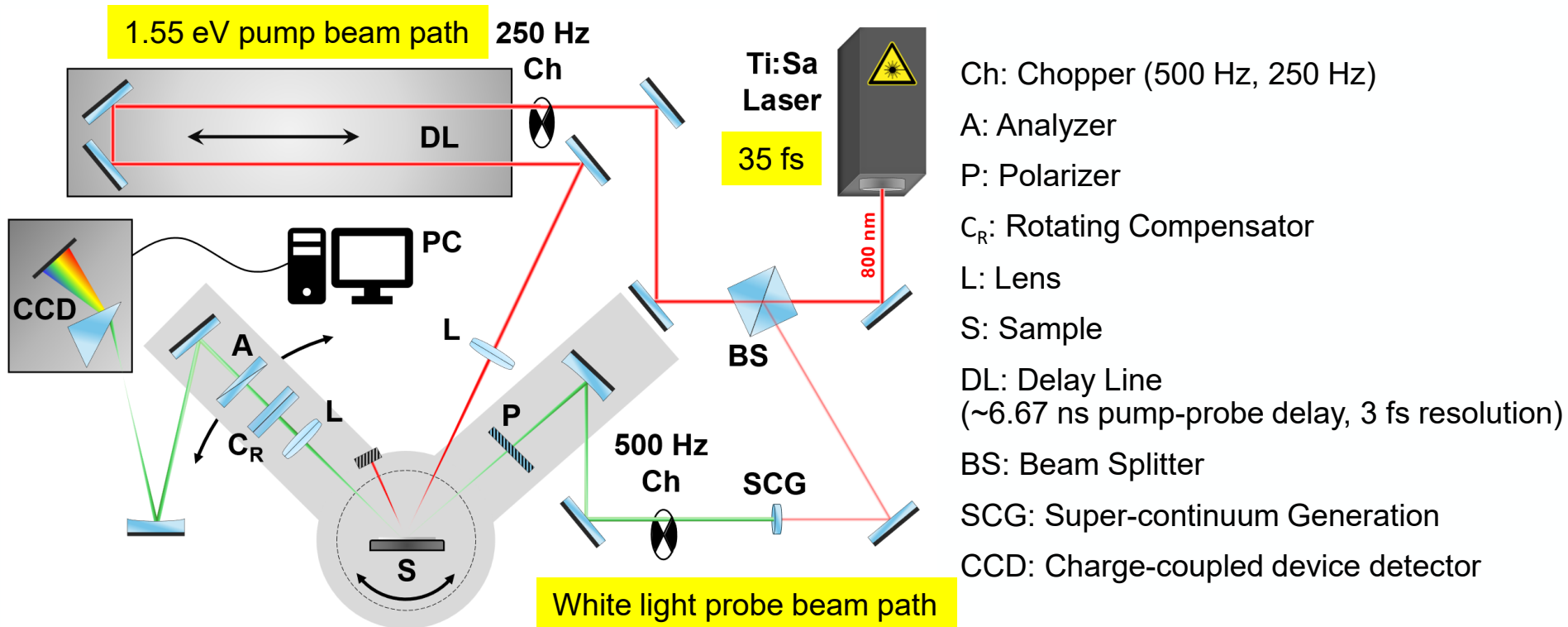
Non-linear effects in germanium induced by photoexcited carriers:

- Screening (many-body)
- Carrier-carrier scattering.
- Carrier-phonon scattering.
- Intervalley scattering.
- Momentum and energy relaxation of hot carriers.

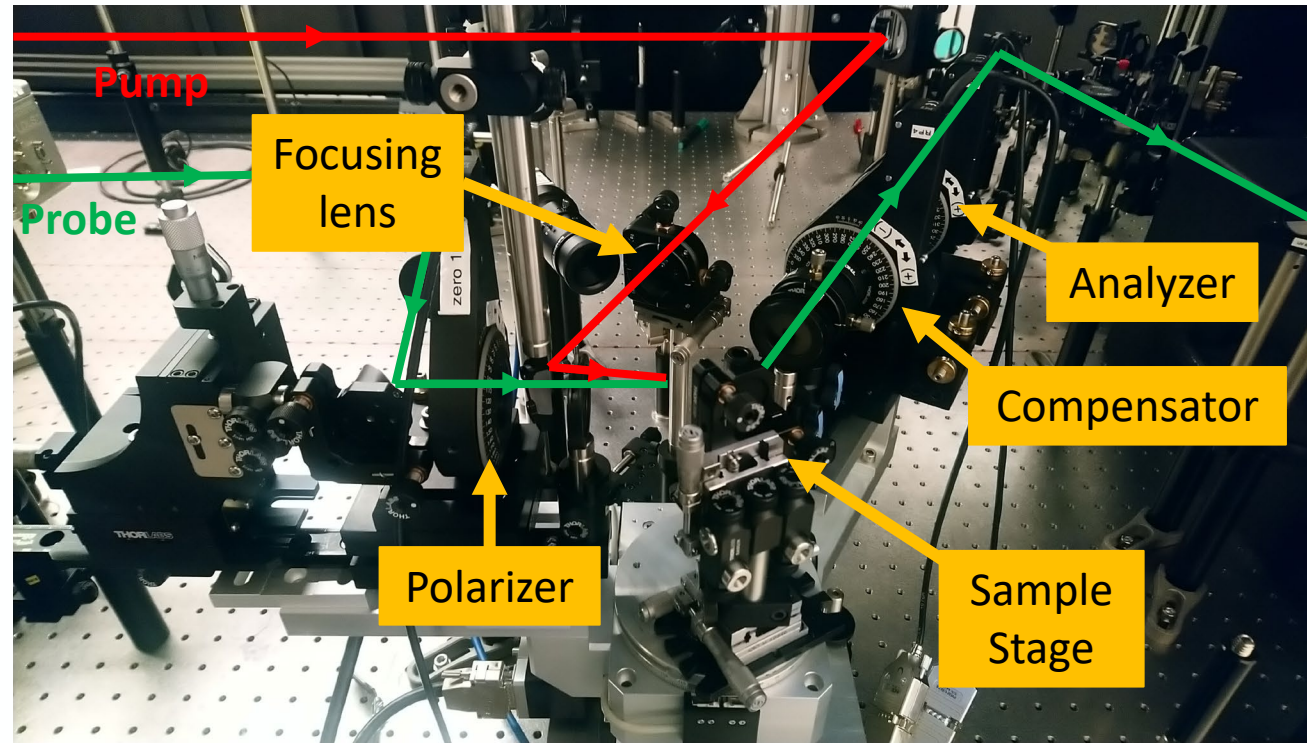
H. Kalt, Semiconductor Optics 2 (2024).

Tompkins & Hilfiker, Spectroscopic Ellipsometry (2016)

# Experimental setup: pump-probe ellipsometry



# Set-up: Femtosecond pump-probe ellipsometry



## Rotating compensator ellipsometer:

Compensator was rotated in steps of  $10^\circ$  for a total of 55-65 angles.

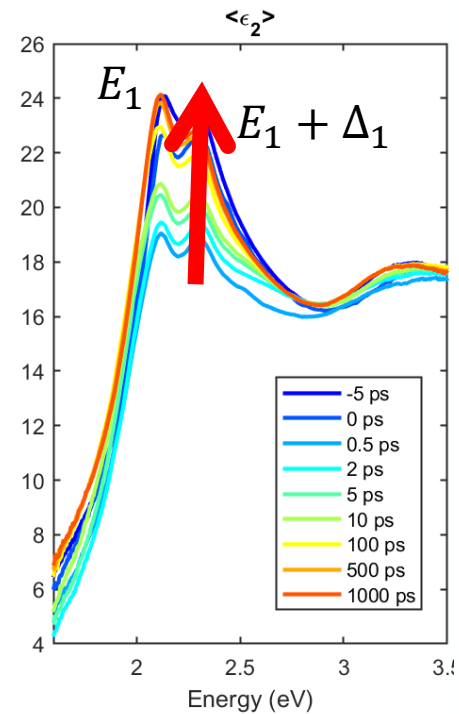
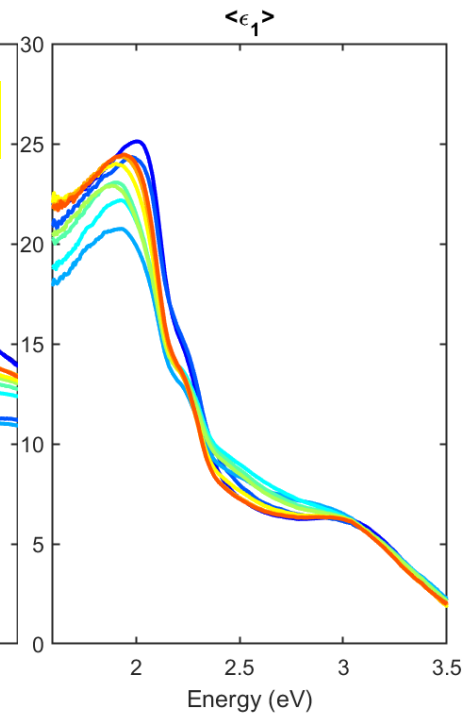
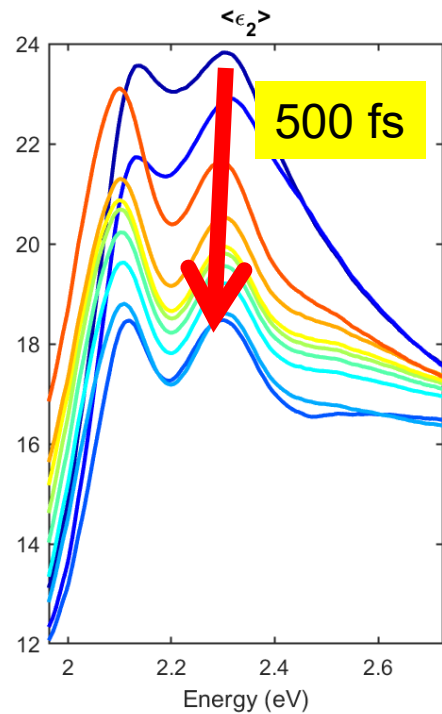
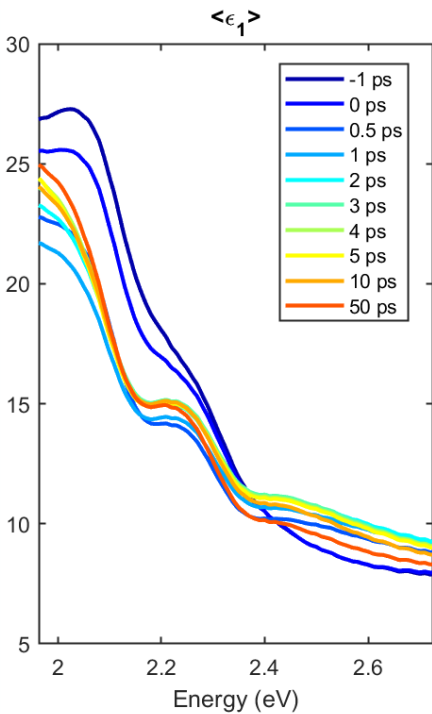
Probe beam of 350-750 nm at  $60^\circ$  incidence angle.

P-polarized pump beam: 35 fs pulses of 800 nm wavelength at 1 kHz repetition rate.

Delay time from -10 to 50 ps.

Time resolution of about 500 fs.

# Pseudo-dielectric constant as function of delay time



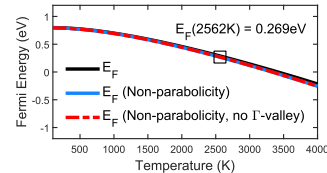
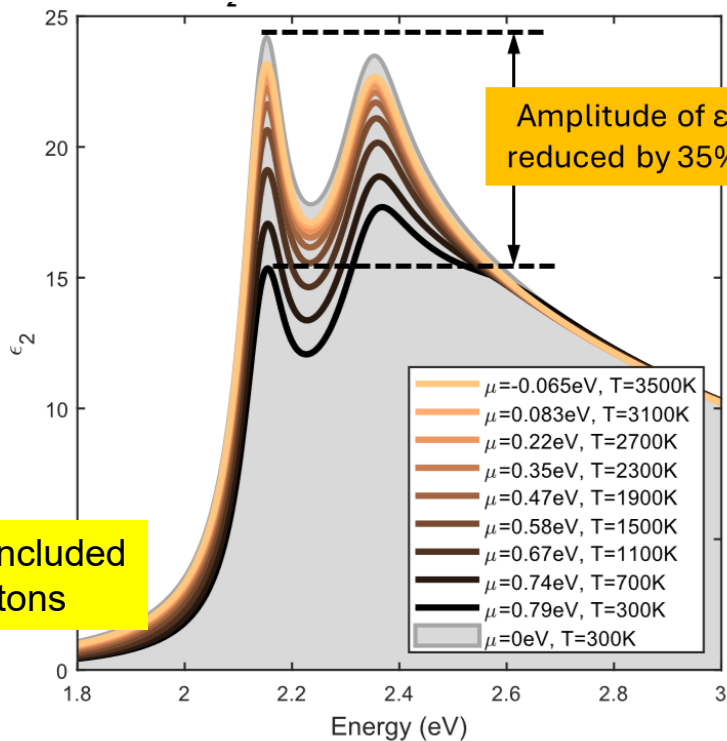
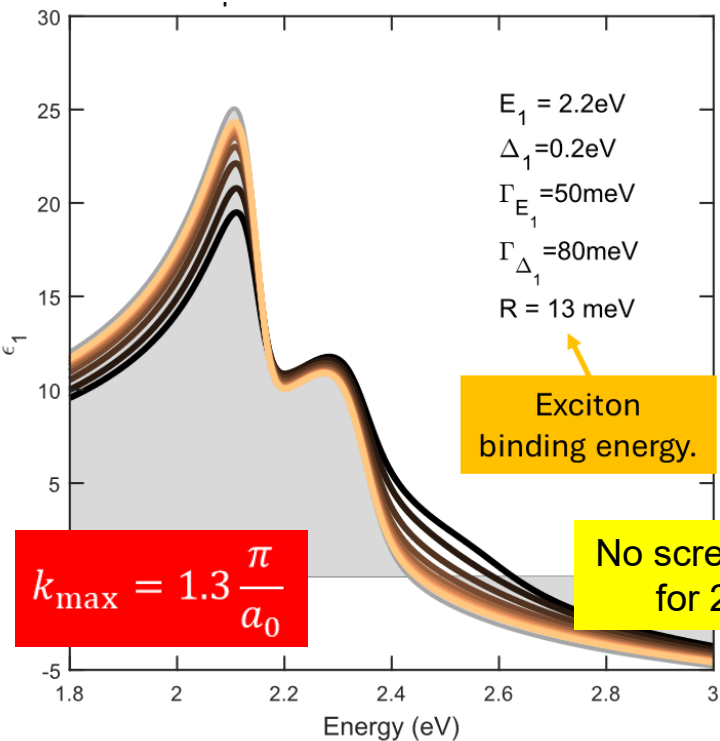
Rapid decrease of  $\epsilon$  within first 500 fs.

Recovery takes 1 ns or longer.



# 2D excitons with band filling - no screening

$$\epsilon_2(E) = \frac{e^2 \mu_{\perp}^{(E_1)} \bar{P}^2}{6\epsilon_0 m^2 \pi} \text{Im} \left\{ \frac{\{g_a[\xi(E + i\Gamma)] + g_a[\xi(-E - i\Gamma)] - 2g_a[\xi(0)]\}}{(E + i\Gamma)^2} \right\} \int_{-k_{\max}}^{k_{\max}} \{1 - f[E_c(E, k_z^2)]\} dk_z$$

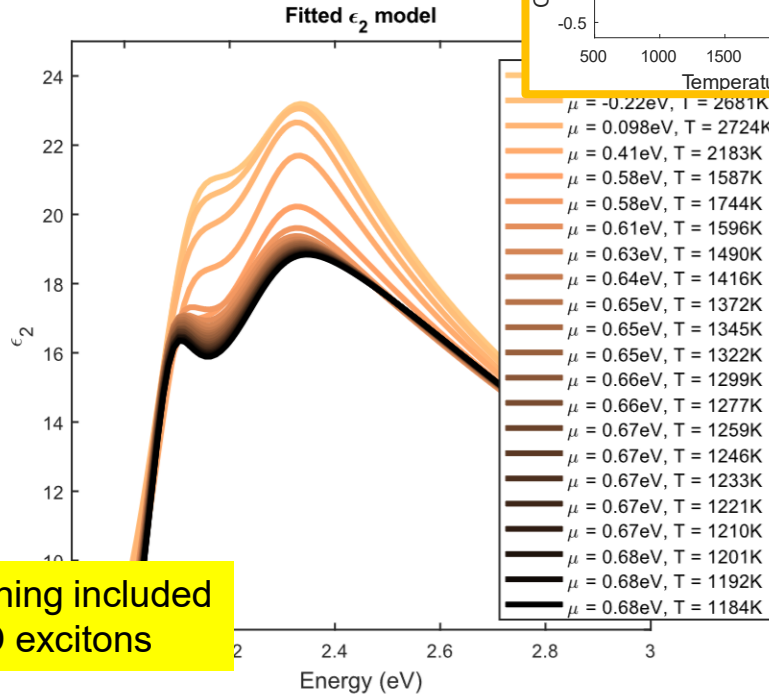
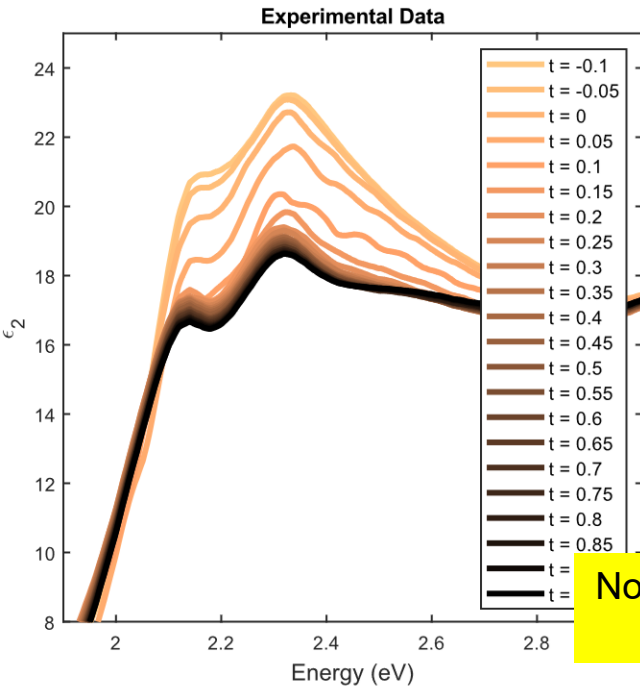


No screening included for 2D excitons

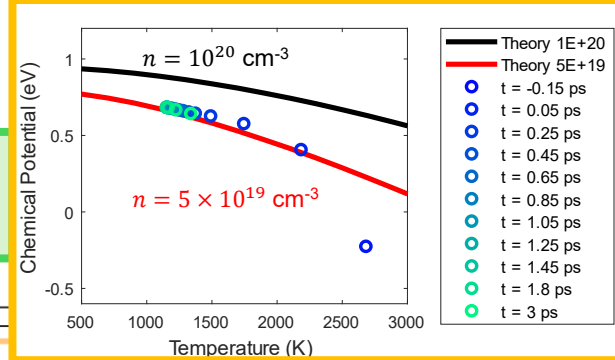
# Band-filling effects

We combine Tanguy's line shape for 2D excitons with Xu's band-filling model:

$$\epsilon_2(E) = \frac{e^2 \mu_{\perp}^{(E_g)} \bar{P}^2}{6\epsilon_0 m^2 \pi} \text{Im} \left\{ \frac{\{g_a[\xi(E + i\Gamma)] + g_a[\xi(-E - i\Gamma)] - 2g_a[\xi(0)]\}}{(E + i\Gamma)^2} \right\} \int_{-k_{\max}}^{k_{\max}} \{1 - f[E_c(E, k_z^2)]\} dk_z$$



No screening included for 2D excitons



Simulation of the chemical potential as a function of temperature for different carrier densities.

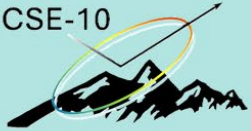
# Summary: Screening of excitons

- Excitonic direct gap absorption: **3D hydrogen problem with Coulomb potential** treated in every quantum mechanics course  
Sommerfeld enhancement of the absorption.
- Screened exciton absorption: 3D hydrogen problem with **Yukawa potential**  
Not solvable analytically, use Hulthen potential (Banyai & Koch, Haug & Koch)  
**Sommerfeld enhancement persists well above the Mott transition.**
- Excitonic direct gap absorption in 2D materials or  $E_1$  excitons  
**2D hydrogen problem** with Coulomb potential (Flügge: Rechenmethoden der QM)
- **Excitonic 2D-transitions at  $E_1$  with screening (femtosecond ellipsometry)**  
**No known solution for screened Sommerfeld enhancement in 2D.**

# Conclusions

- Quantitative modeling of low-density optical processes is possible with basic physics and matrix elements from k.p theory:
  - Photoluminescence in Ge (Menendez)
  - Indirect gap absorption in Ge (Menendez)
  - **Direct gap absorption in Ge at low T (excitons in 3D);  $E_1$  critical points in Ge (excitons in 2D)**
  - More work is needed at high temperatures and for materials other than Ge.
- High carrier excitations:
  - High electron doping density in Ge
  - **Thermal excitation of electron-hole pairs in InSb and  $\alpha$ -tin (3D screening and band filling).**
  - **Femtosecond laser generation of electron-hole pairs in Ge (2D screening)**
  - Experimental data and qualitative explanations exist
- We need more experiments and more detailed theory and simulations.

ICSE-10



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## 10th International Conference on Spectroscopic Ellipsometry

June 8–13, 2025, in Boulder, CO, USA





**Thank you!**

**Questions?**

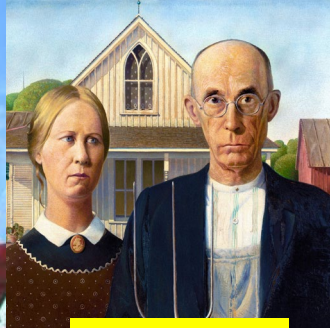
**Many students  
contributed to  
this project.**

<http://femto.nmsu.edu>



# Biography

Regensburg/Stuttgart  
Germany



Motorola (Mesa, Tempe)  
Arizona, 1997-2005



Ames, IA



Freescale, IBM  
New York, 91-92; 07-10



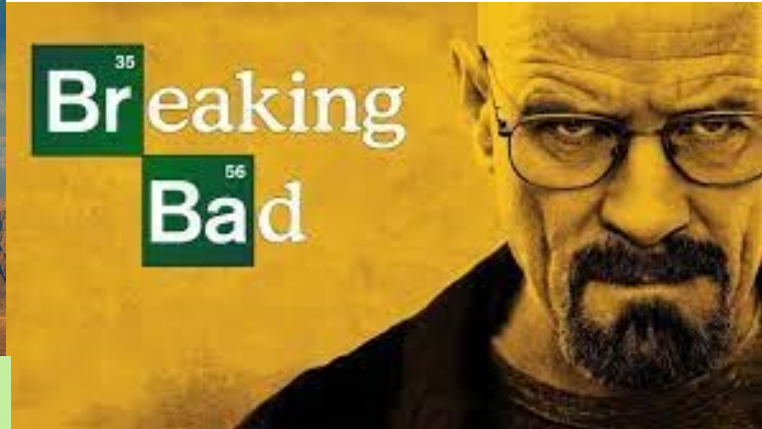
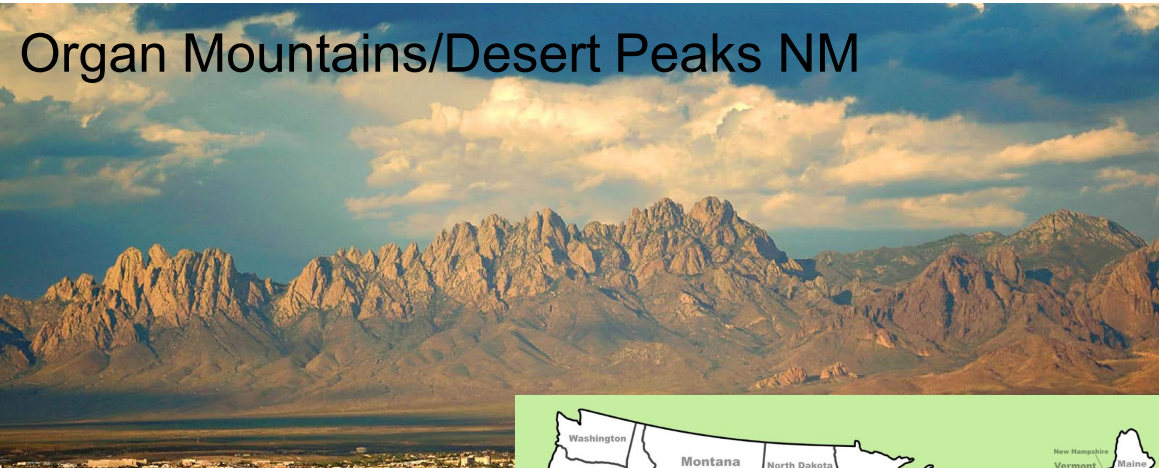
NMSU  
Las Cruces, NM  
Since 2010

Motorola, Freescale  
Texas, 2005-2007





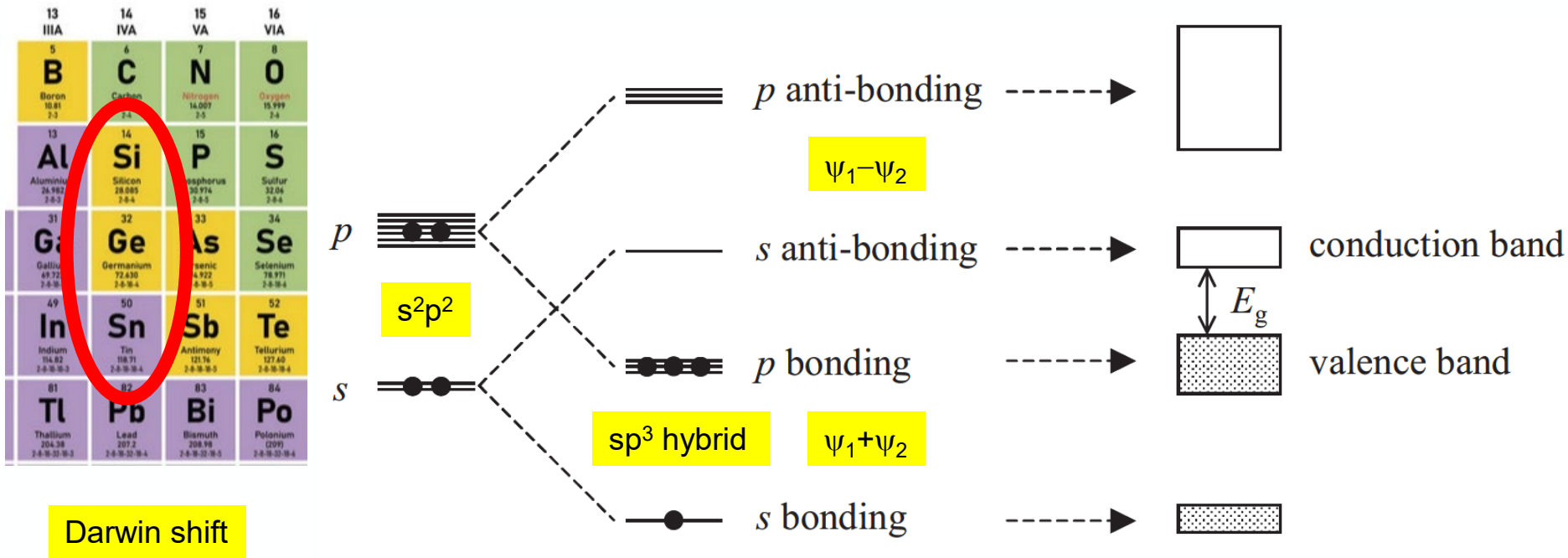
# Where is Las Cruces, NM ???



White Sands NP



# Ge Band structure: where did this come from?



Darwin shift

Add kinetic energy

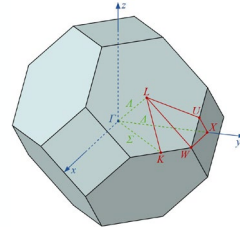
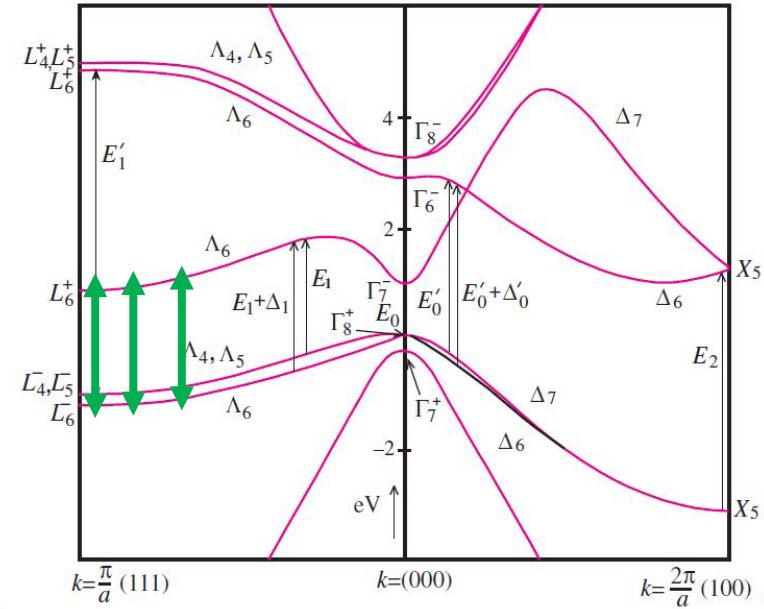
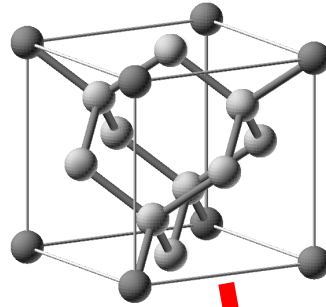
ATOM      →      MOLECULE      →      CRYSTAL

Works well for Ge, GaAs, etc.

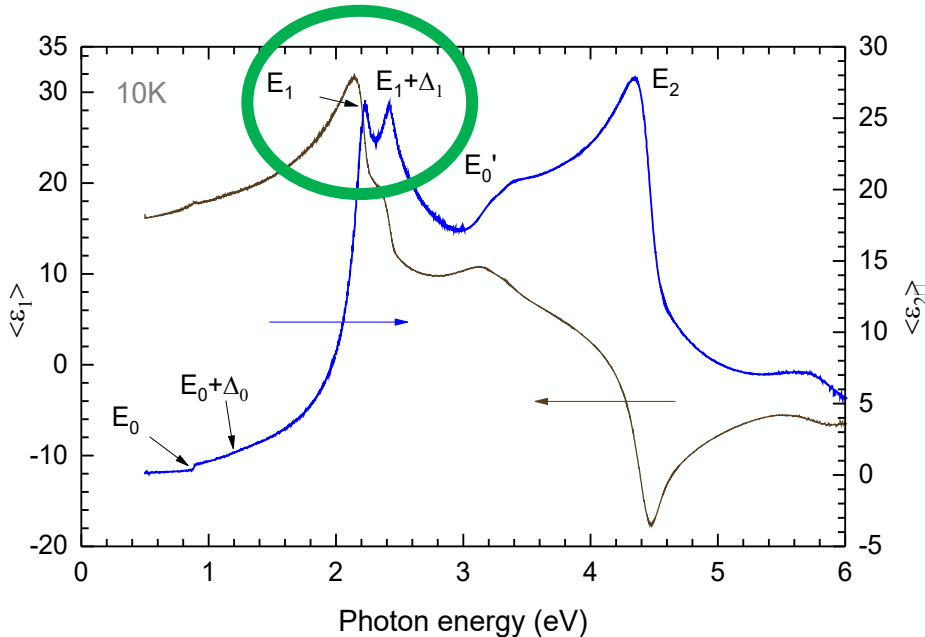
Fox, Chapter 3

# Critical points in the dielectric function of Ge

- Peaks in the dielectric function
- Due to interband transitions from valence to conduction band (electron-hole pairs)



$$\psi(\vec{r}) = e^{i\vec{k}\cdot\vec{r}} u_{n,\vec{k}}(\vec{r})$$



# Two-dimensional Bohr problem

$$H = -\frac{\hbar^2}{2\mu_{\perp}} \left( \frac{\partial^2}{\partial x^2} + \frac{\partial^2}{\partial y^2} \right) - \frac{\hbar^2}{2\mu_{\parallel}} \frac{\partial^2}{\partial z^2} - \frac{e^2}{\epsilon_r r}$$

Assume that  $\mu_{\parallel}$  is infinite (separate term).  
 Use cylindrical coordinates.  
 Separate radial and polar variables.  
 Similar Laguerre solution as 3D Bohr problem.

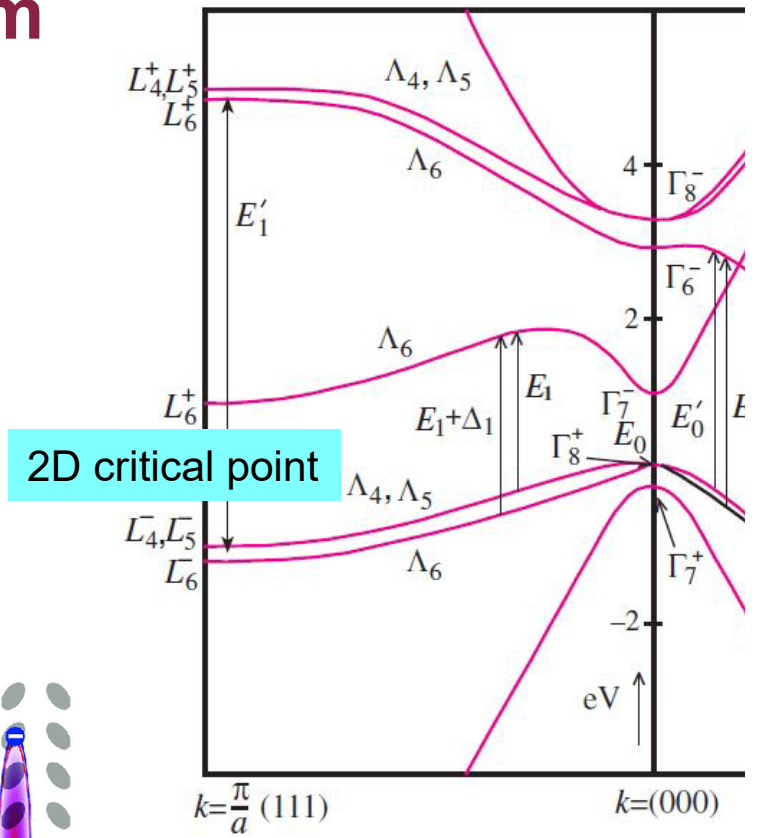
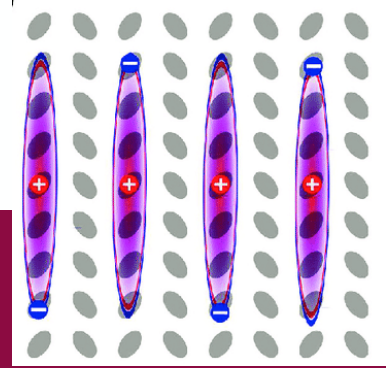
$$a_X = \frac{4\pi\epsilon_0\epsilon_r\hbar^2 m_0}{\mu_{\perp}\mu e^2}$$

$$R = \frac{\mu_{\perp} e^4}{2\hbar^2 m_0 (4\pi\epsilon_0\epsilon_r)^2}$$

$$E_n = -\frac{R}{\left(n - \frac{1}{2}\right)^2}, \quad n = 1, 2, \dots$$

Half-integral quantum numbers

STATE BE BOLD. Shape the Future.



M. Shinada and S. Sugano, J. Phys. Soc. Jpn. **21**, 1936 (1966).

# Two-dimensional saddle-point excitons ( $E_1, E_1 + \Delta_1$ )

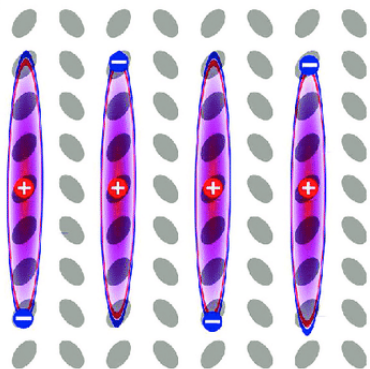
$$\varepsilon(E) = \frac{A}{(E + i\Gamma)^2} \{g[\xi(E + i\Gamma)] + g[\xi(-E - i\Gamma)] - 2g[\xi(0)]\}$$

$$g(\xi) = 2\ln(\xi) - 2\psi\left(\frac{1}{2} - \xi\right)$$

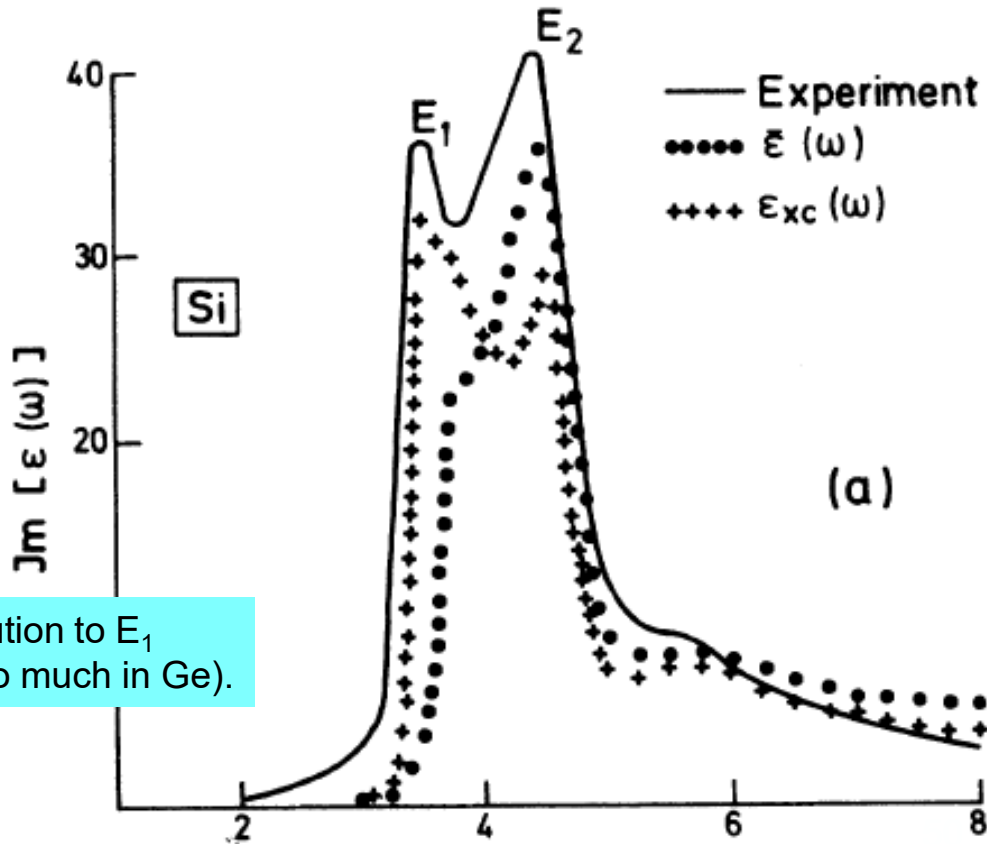
$$\psi(z) = \frac{d\ln\Gamma(z)}{dz}$$

$$\xi(z) = \sqrt{R/E_0 - z}$$

$$A = \frac{\mu e^2}{3\pi\varepsilon_0 m_0^2} |P|^2$$



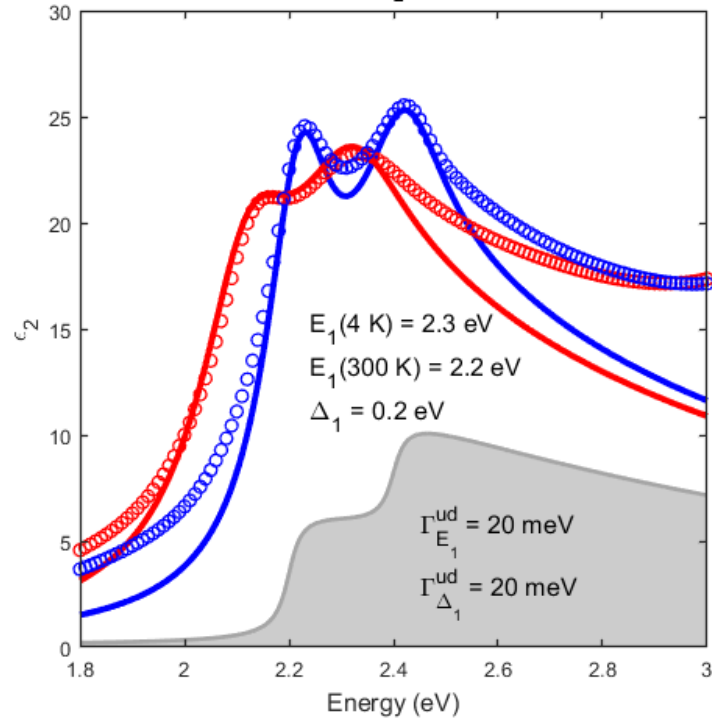
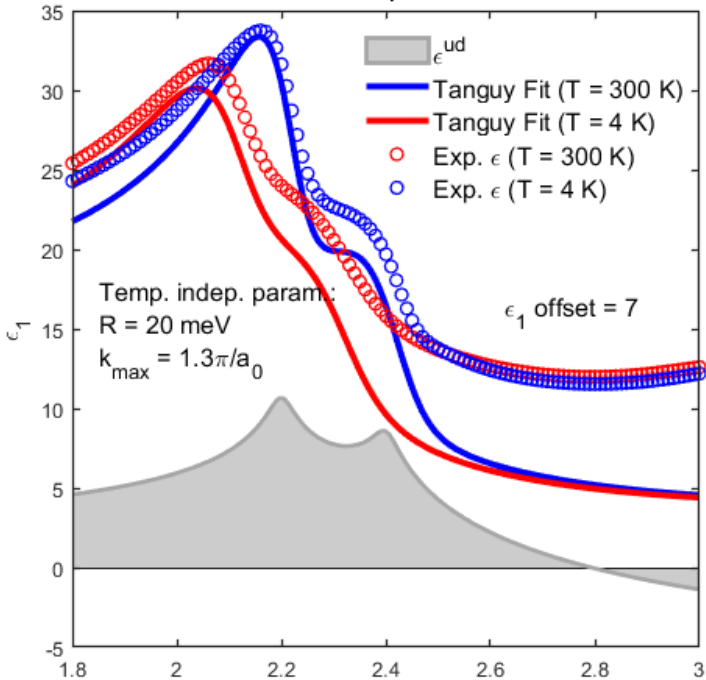
Strong excitonic contribution to  $E_1$  critical point in Si (not so much in Ge).



B. Velicky and J. Sak, *phys. status solidi* **16**, 147 (1966)  
 C. Tanguy, *Solid State Commun.* **98**, 65 (1996)  
 W. Hanke and L.J. Sham, *Phys. Rev. B* **21**, 4656 (1980)

# Comparison with experimental data

$$\varepsilon(E, E_1, \Gamma, R, k_{\max}) = \frac{k_{\max} e^2 \bar{P}^2 \mu_{\perp}^{(E_1)}}{3 \varepsilon_0 m^2 \pi (E + i\Gamma)^2} \left\{ g_a \left[ \sqrt{\frac{R}{E_1 - (E + i\Gamma)}} \right] + g_a \left[ \sqrt{\frac{R}{E_1 - (-E - i\Gamma)}} \right] - 2g_a \left[ \sqrt{\frac{R}{E_1 - (0)}} \right] \right\}$$

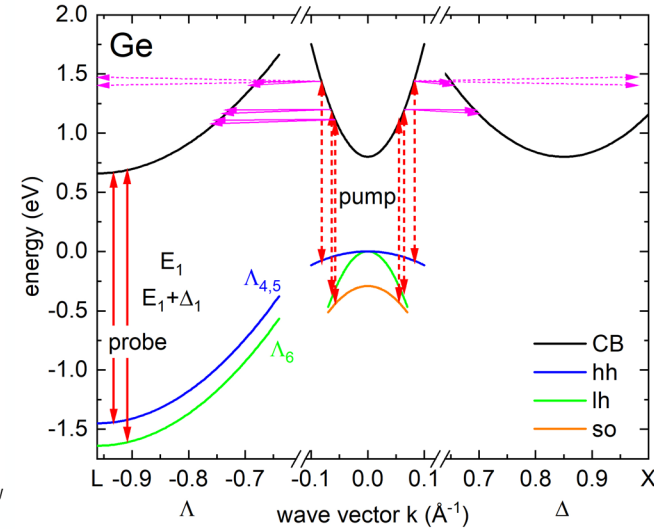
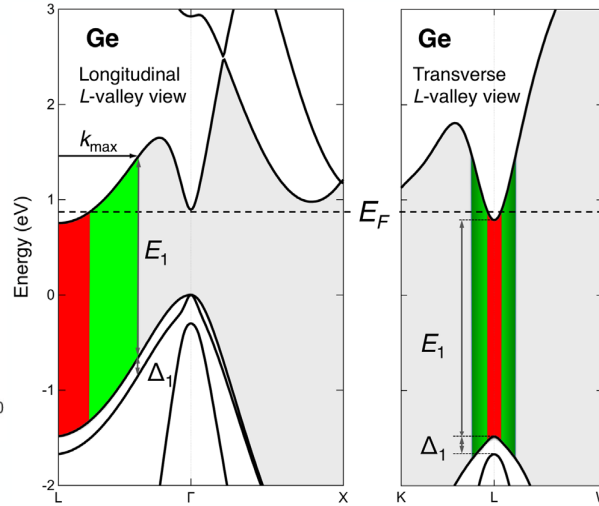
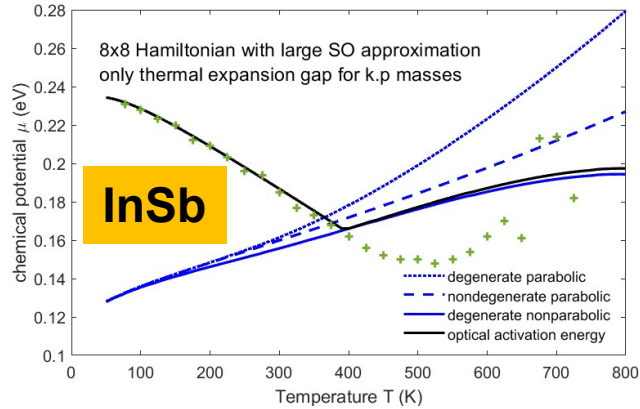


Experimental data:

Emminger (5 K),  
 JVST B **38**,  
 012202 (2020).

Nunley (300 K),  
 JVST B **34**,  
 061205 (2016)

# Optical Absorption at High Carrier Densities



**High temperature**  
(thermal excitation of e-h pairs)  
constant  $m$  and  $E_0$

**High n-doping of Ge with P**  
(free electrons pile up at L-point)

**Intense femtosecond laser excitation** (ELI Beamlines)  
(electrons pile at L-point)

Rivero, JVSTB **41**, 022203 (2023)

Xu et al., PRL **118**, 267402 (2017)

Espinoza, APL **115**, 052105 (2019)